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**1960-20**

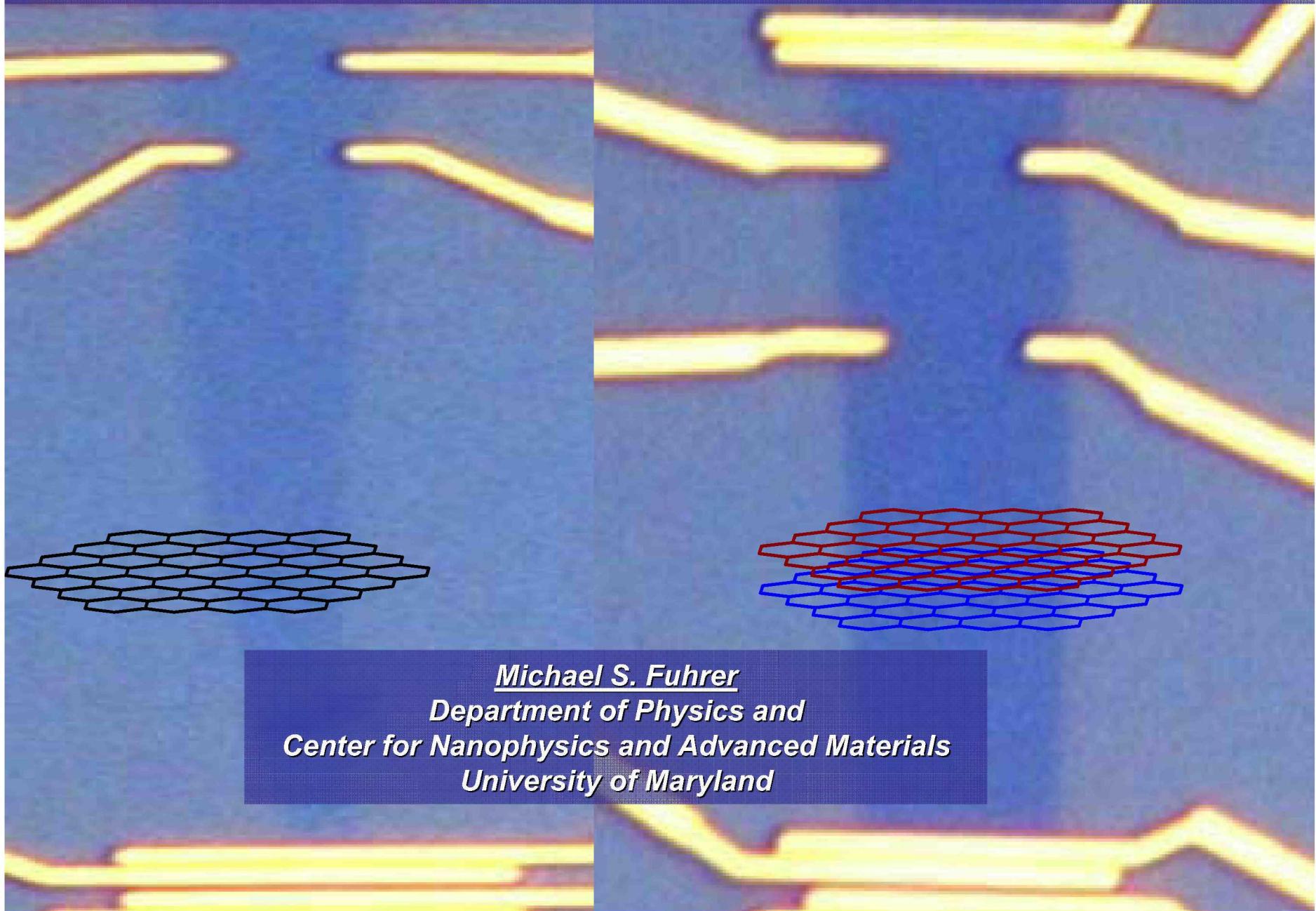
**ICTP Conference Graphene Week 2008**

*25 - 29 August 2008*

**Probing diffusive and ballistic transport in graphene**

M.S. Fuhrer  
*Department of Physics and  
Center for Nanophysics and Advanced Materials  
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U.S.A.*

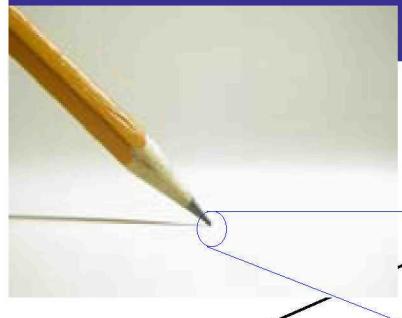
# Probing Diffusive and Ballistic Transport in Graphene



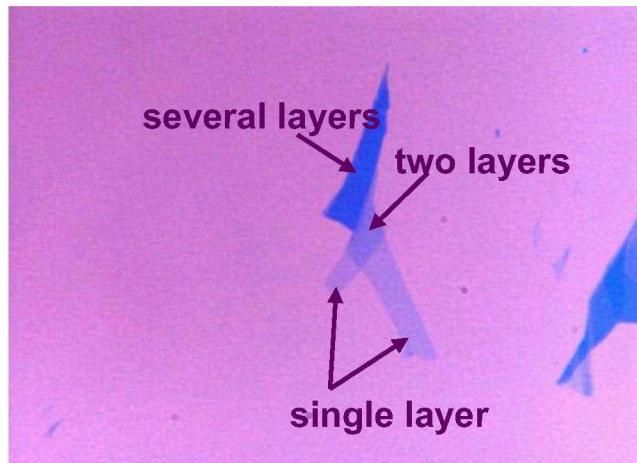
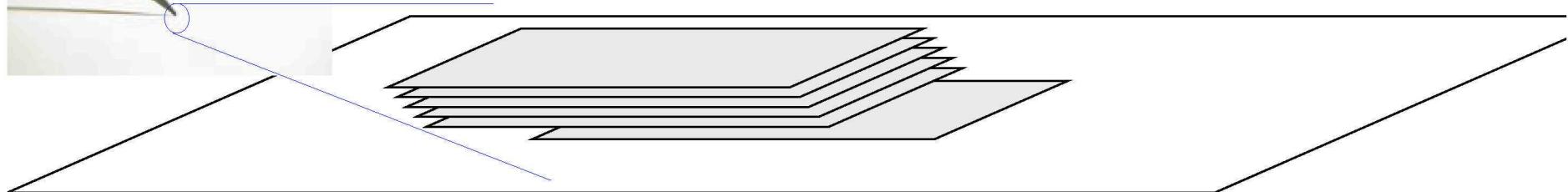
*Michael S. Fuhrer*  
*Department of Physics and*  
*Center for Nanophysics and Advanced Materials*  
*University of Maryland*

# Outline

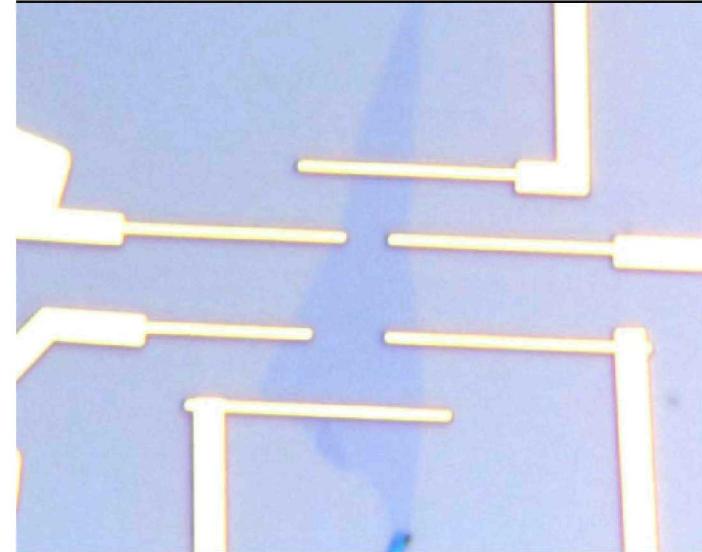
- I. Introduction to Graphene
  - “Massless” electrons
  - Pseudospin and Berry’s phase
- II. Fabrication and Characterization of Graphene on SiO<sub>2</sub>
  - Micro-Raman spectroscopy
  - Scanning Tunneling Microscopy
- III. Diffusive Transport in Graphene
  - Boltzmann Transport
  - Charged impurities
  - Effect of Dielectric Environment
  - Corrugations
  - Phonons
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  - Single and Bilayer Graphene
  - Fabry-Perot Interference → Density of States



# Graphene – Fabrication



Optical micrograph (layer thickness verified by AFM)



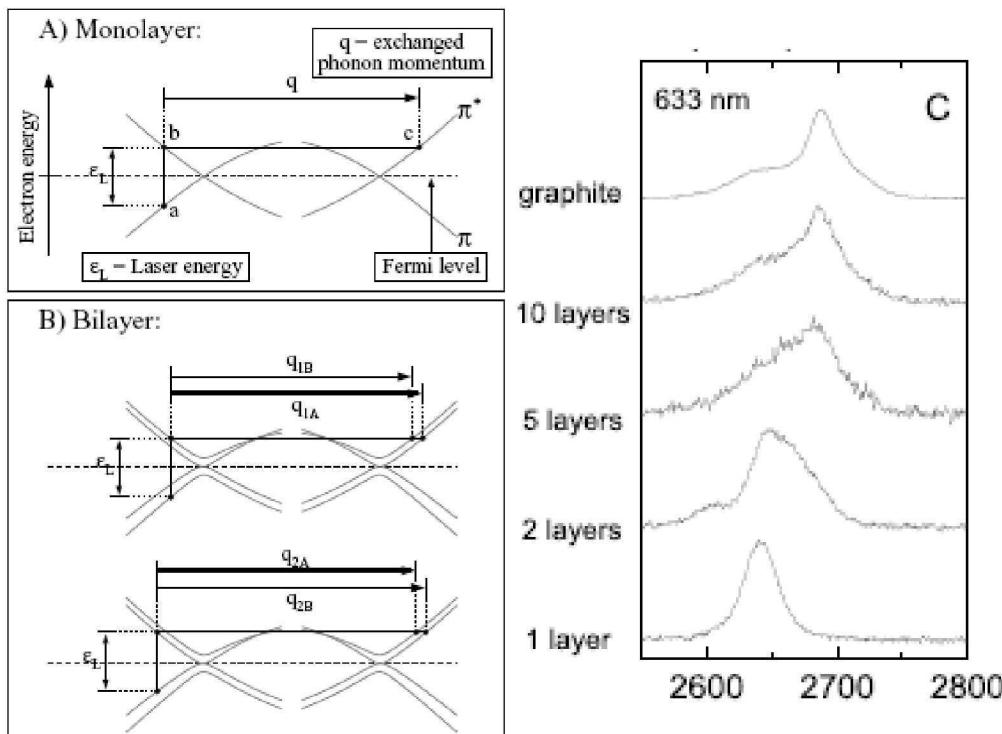
Single layer device after e-beam lithography

- Starting material is single-crystal Kish graphite
- Mechanically exfoliate on 300 nm SiO<sub>2</sub>/Si chips

Method adapted from Novoselov, et al. *PNAS* **102** 10341 (2005)

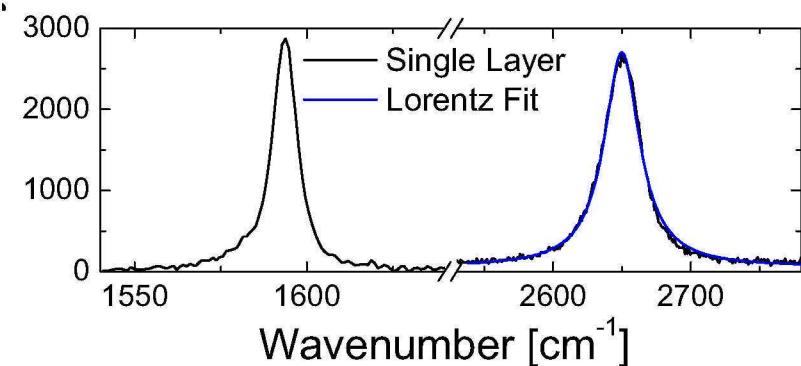
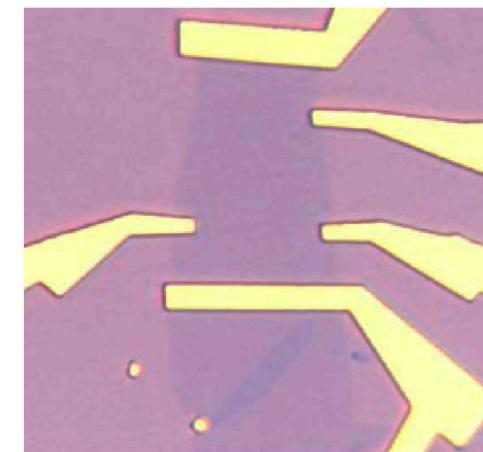
# Graphene fingerprint in Micro-Raman

- Raman G' band is two-photon/two-phonon resonant excitation; sensitive to electronic structure of graphene



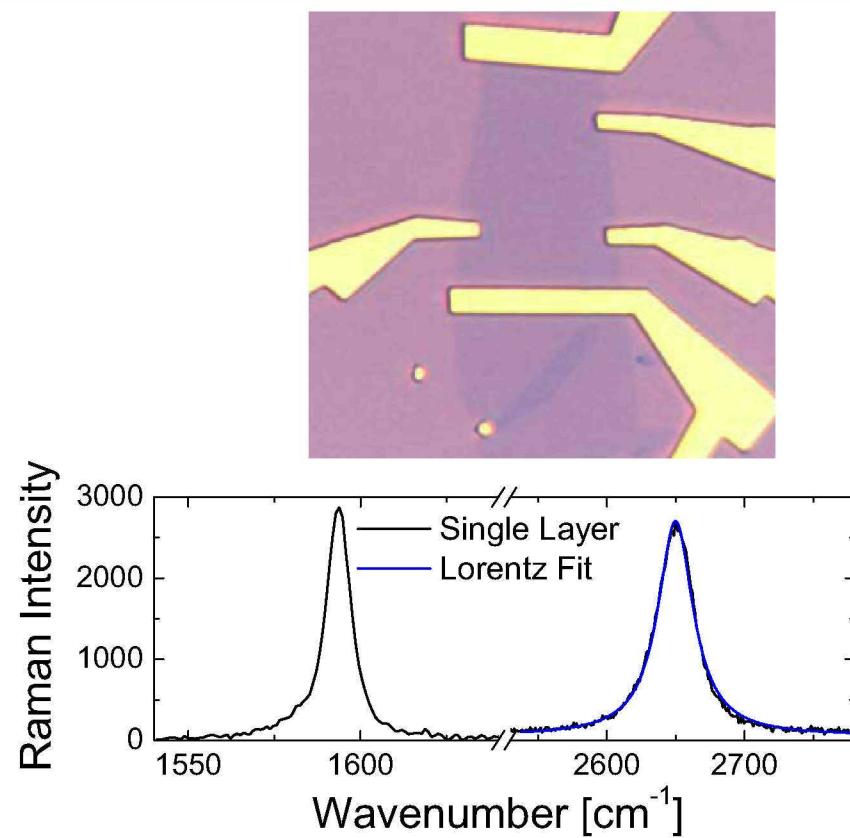
Ferrari, et al., *PRL* **97**, 187401 (2006)

Führer group sample

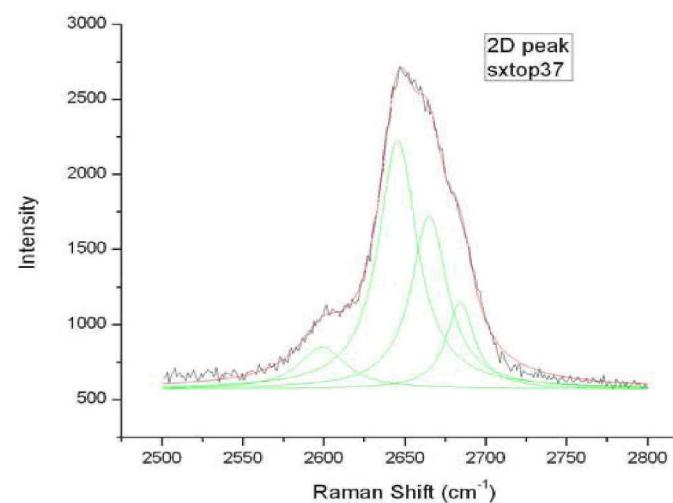
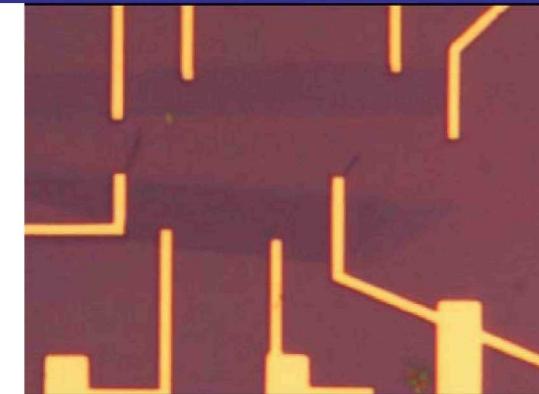


single Lorentzian G' peak indicates  
single-layer graphene

# Single-layer vs. Bilayer in micro-Raman



single Lorentzian G' peak indicates  
single-layer graphene

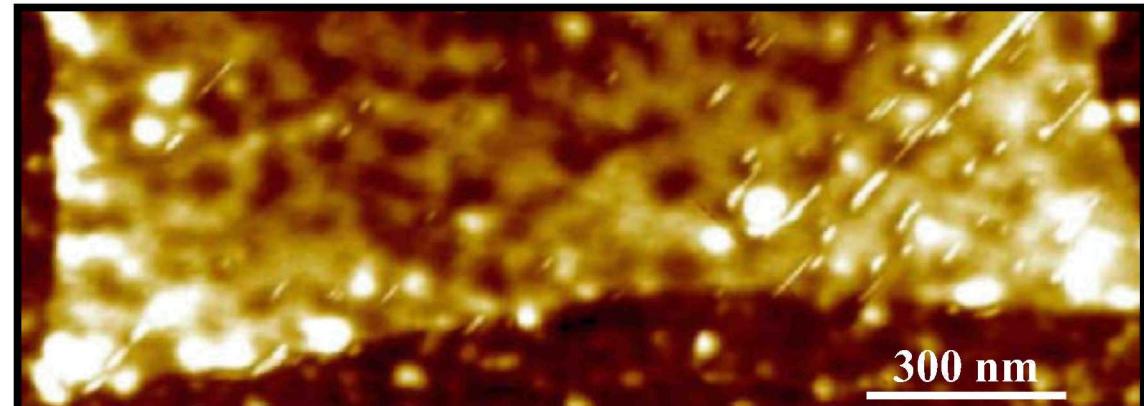
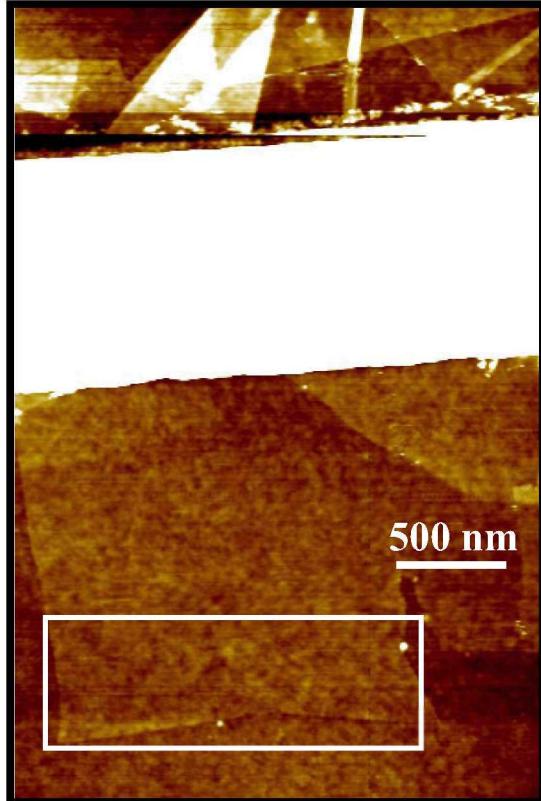


bilayer graphene shows characteristic  
four-fold splitting of G' peak

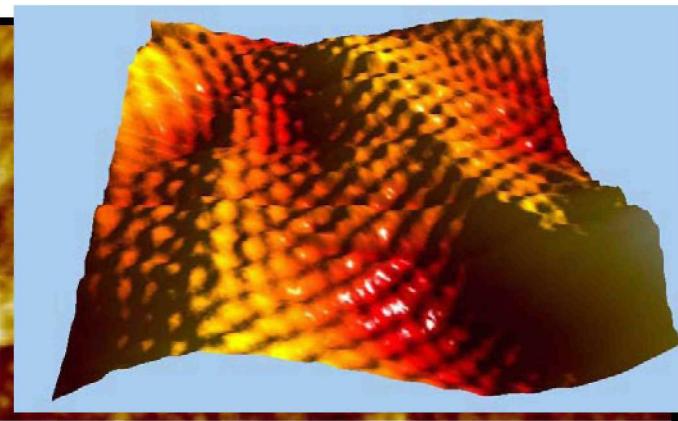
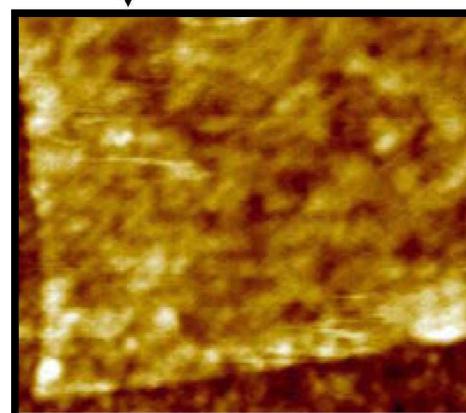
# Removing Photoresist Residue from Graphene

Ishigami, et al., *Nano Letters* 7, 1643 (2007)

Residues from PMMA/MMA photoresist



Novel photoresist residue removal process  
Anneal in flowing H<sub>2</sub> at 400°C



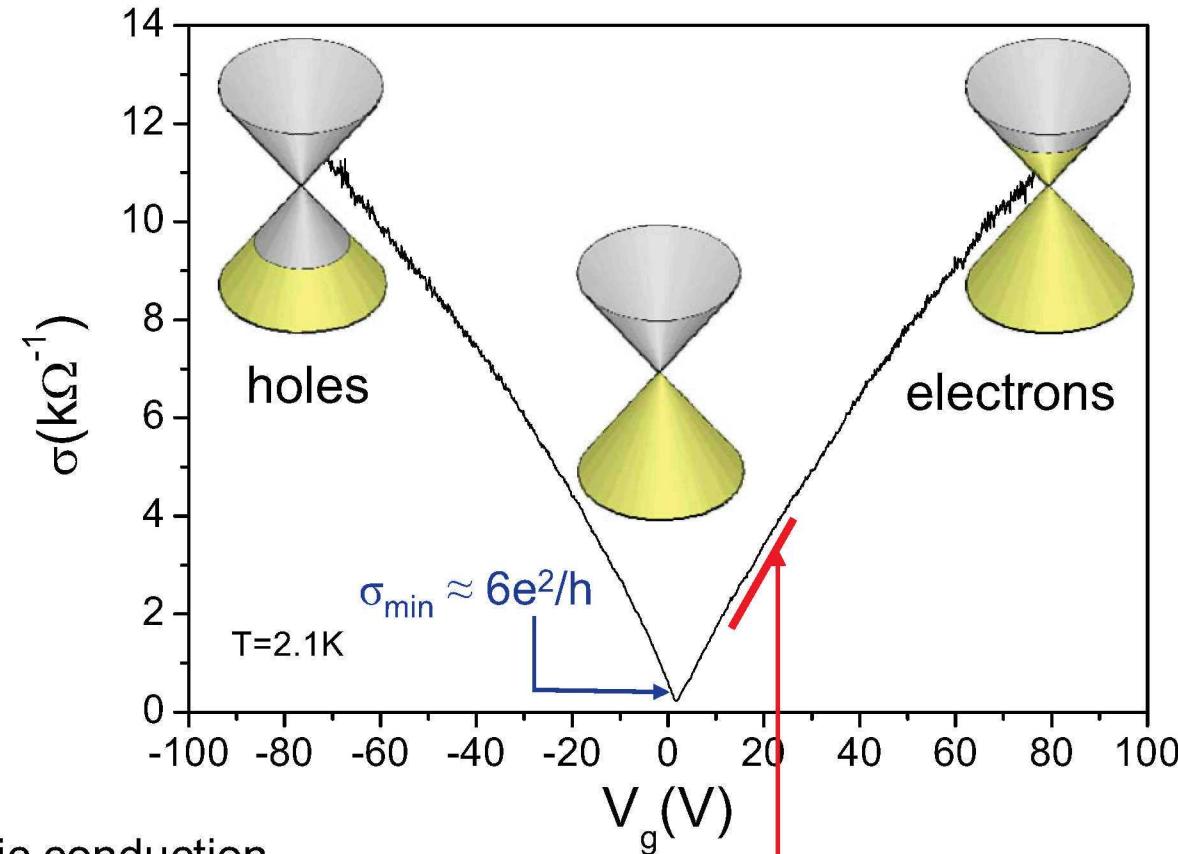
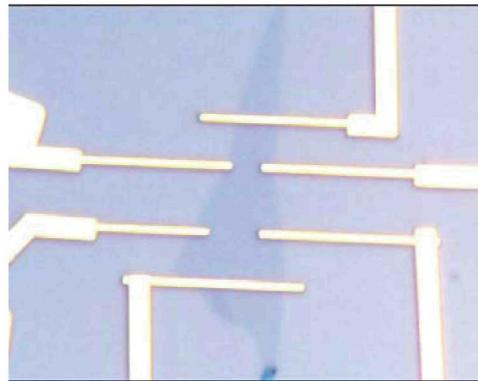
Complete removal of photoresist residues

Atomically clean STM images

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# Electrical Characterization of Graphene



- Ambipolar, symmetric conduction
- Finite minimum conductivity  $\sim [4-10]e^2/h$
- Field-effect mobility up to  $20,000\text{ cm}^2/\text{Vs}$
- on/off ratio of 50-100:1
- Sheet resistance of  $\sim 100\text{ }\Omega/\text{square}$  at high  $V_g$

$$\mu_{FE} = \frac{1}{e} \frac{d\sigma}{dn} = \frac{1}{c_g} \frac{d\sigma}{dV_g}$$

# Boltzmann Transport

$$\sigma = \frac{e^2 v_F^2}{2} D(E) \tau$$

$D(E)$  is density of states  
 $\tau$  is momentum relaxation time  
 $v_F$  is Fermi velocity

Graphene:  $D(E) = \frac{2E_F}{\pi \hbar^2 v_F^2}$

$$\sigma = \frac{e^2}{\pi \hbar^2} E_F \tau \quad \text{or} \quad \sigma = \frac{2e^2}{h} k_F l$$

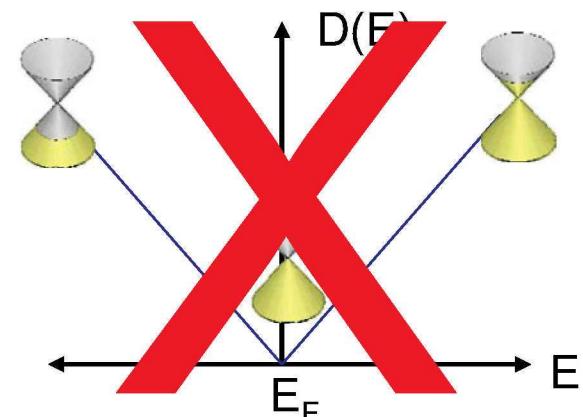
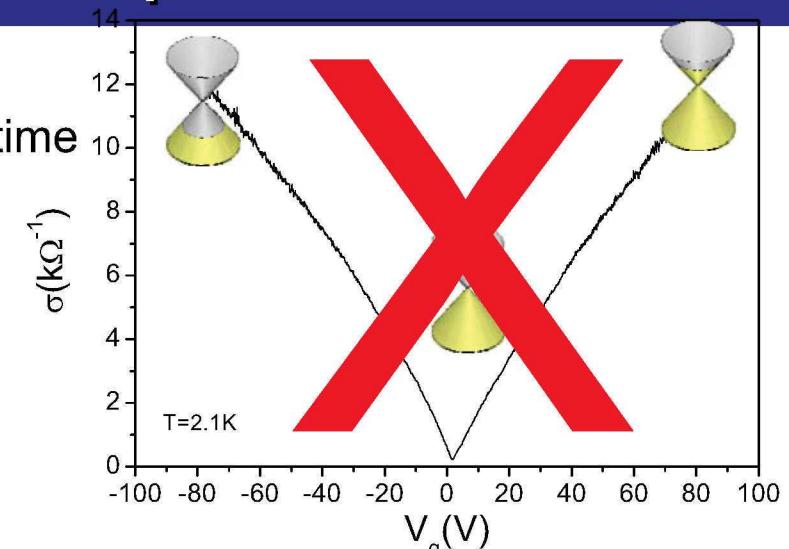
Fermi's Golden Rule:

$$\frac{1}{\tau} \propto \frac{2\pi}{\hbar} \left| \langle k | V | k' \rangle \right|^2 D(E)$$

$$\tau \propto D(E)^{-1} \propto E_F^{-1}$$



$\sigma$  is independent of  $E_F$ !



True for point defects, phonons  
 see e.g. T. Ando (1996)

# How to explain linear $\sigma(V_g)$ ?

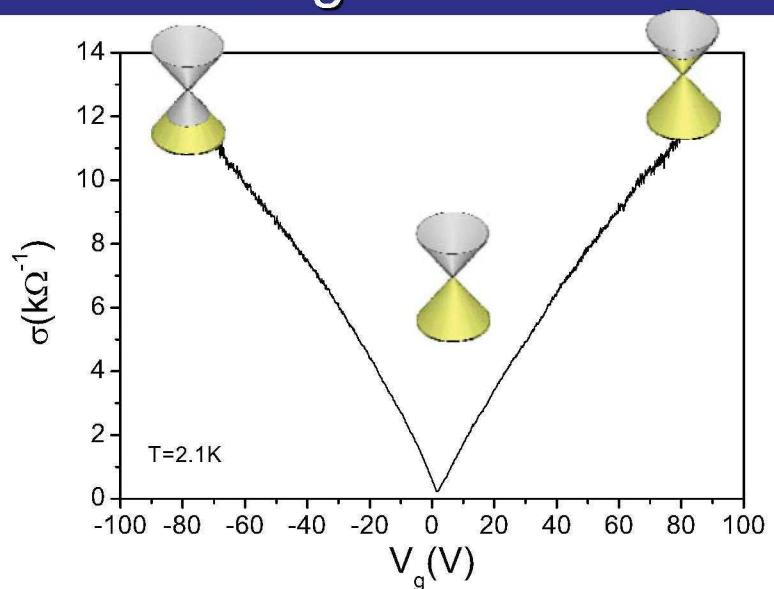
$$\sigma = \frac{e^2}{\pi \hbar^2} E_F \tau$$

$$\frac{1}{\tau} \propto \frac{2\pi}{\hbar} \left| \langle k | V | k' \rangle \right|^2 D(E)$$

Interaction must be  $q$ -dependent

$$q = |\mathbf{k} - \mathbf{k}'| \sim k_F$$

Coulomb interaction:  $V_{Coulomb} = \frac{2\pi e^2}{kq}$



N.B. In graphene, *screened* Coulomb interaction remains  $\sim 1/k_F$



$$\sigma \sim E_F^{1/2} \sim n \sim V_g$$

See:

Ando, *J. Phys. Soc. Jpn.* **75**, 074716 (2006)

Nomura & MacDonald *PRL* **98**, 076602 (2007)

Cheianov & Fal'ko *PRL* **97**, 226801 (2006)

Hwang, Adam, & Das Sarma, *PRL* **98**, 186806 (2007)

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# Charged Impurity Scattering: Potassium Doping in UHV

J. H. Chen, et al. *Nature Physics* 4, 377 (2008)

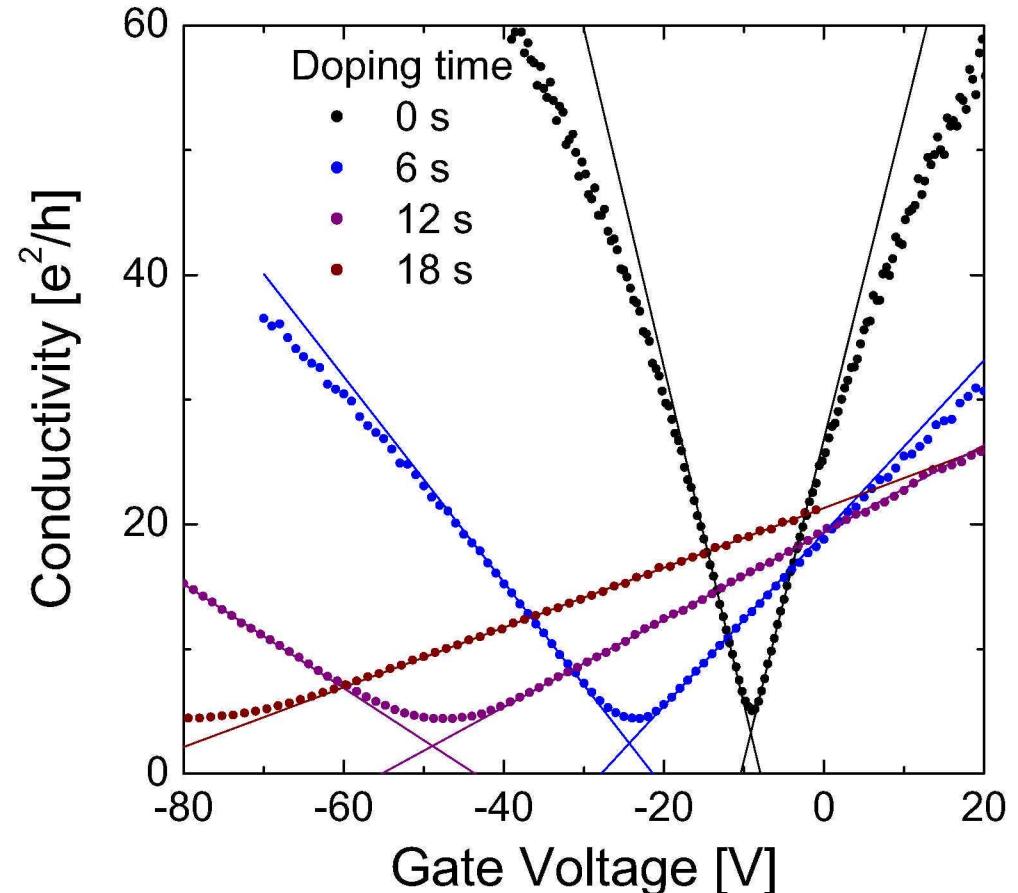
- Clean graphene in UHV at  $T = 20$  K
- Potassium evaporated on graphene from getter

Upon doping with K:

- 1) mobility decreases
- 2)  $\sigma(V_g)$  more linear
- 3)  $\sigma_{\min}$  shifts to negative  $V_g$
- 4) plateau around  $\sigma_{\min}$  broadens
- 5)  $\sigma_{\min}$  decreases (slightly)

All these feature predicted for Coulomb scattering in graphene

Adam, et al., PNAS 104, 18392 (2007)



# Charged Impurity Scattering: High Carrier Density

J. H. Chen, et al. *Nature Physics* **4**, 377 (2008)

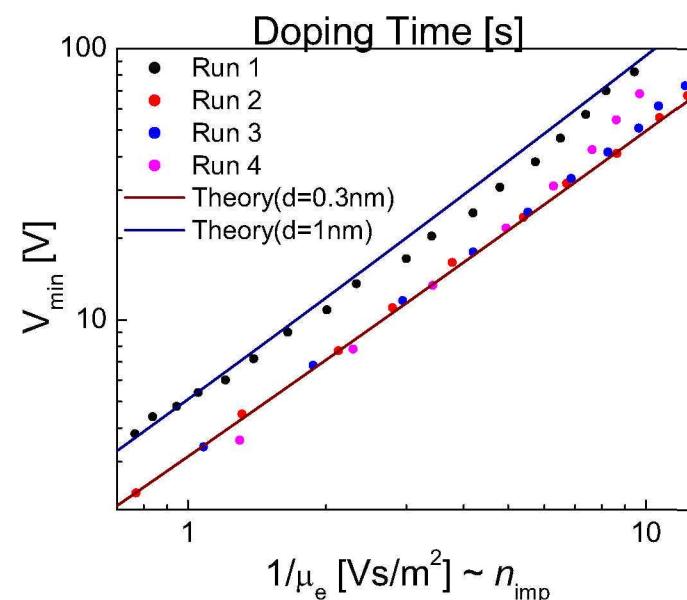
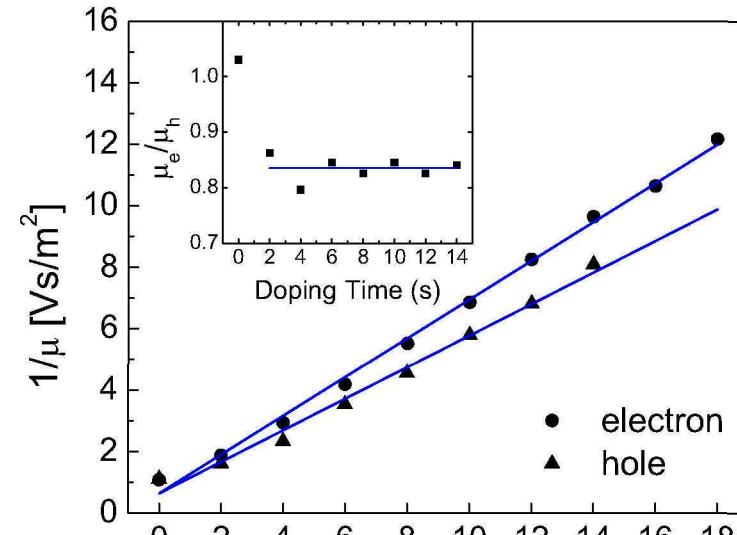
- Theory:

[Adam, et al., *PNAS* **104**, 18392 (2007)]

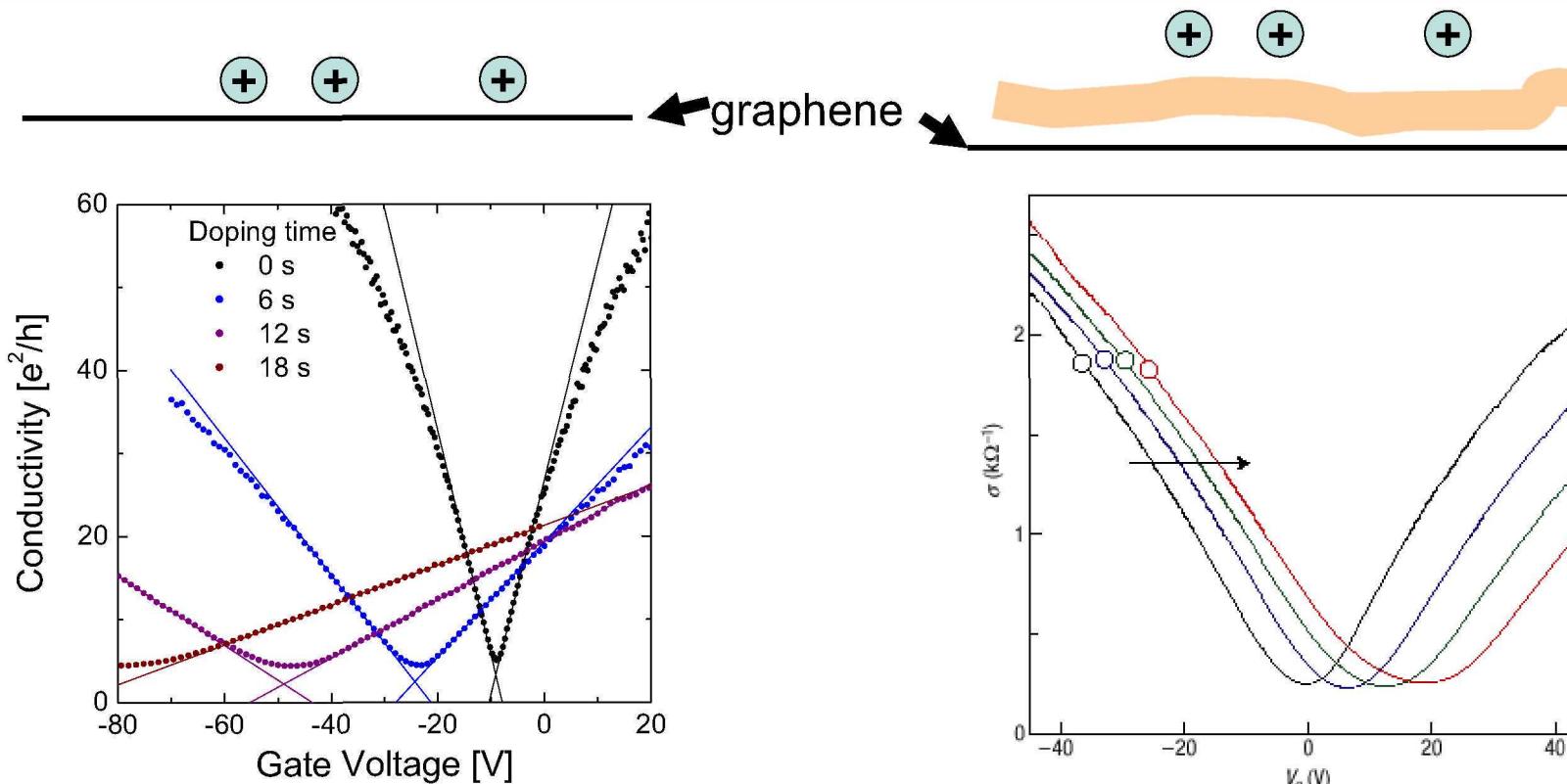
$$[\mu(\text{cm}^2/\text{Vs})] = \frac{C}{[n_{\text{imp}}(\text{cm}^{-2})]} \quad C = 5 \times 10^{11} \text{ Vs}$$

- $1/\mu$  vs. doping time
  - $V_{\min}$  vs.  $1/\mu$
- consistent with  $C = 5 \times 10^{11} \text{ Vs}$
- 
- $e-h$  asymmetry predicted for Dirac fermions

[Novikov, *APL* **91**, 102102 (2007)]



# Why must graphene be atomically clean?



J. H. Chen, et al. *Nature Physics* **4**, 377 (2008)

F. Schedin, et al. *Nat. Mat.* **6**, 652 (2007)

$$\frac{1}{\mu} = \frac{n_{imp}}{\left[ 5 \times 10^{11} Vs \right]}$$

$$\frac{1}{\mu} = \frac{n_{imp}}{\left[ 10^{13} Vs \right]}$$

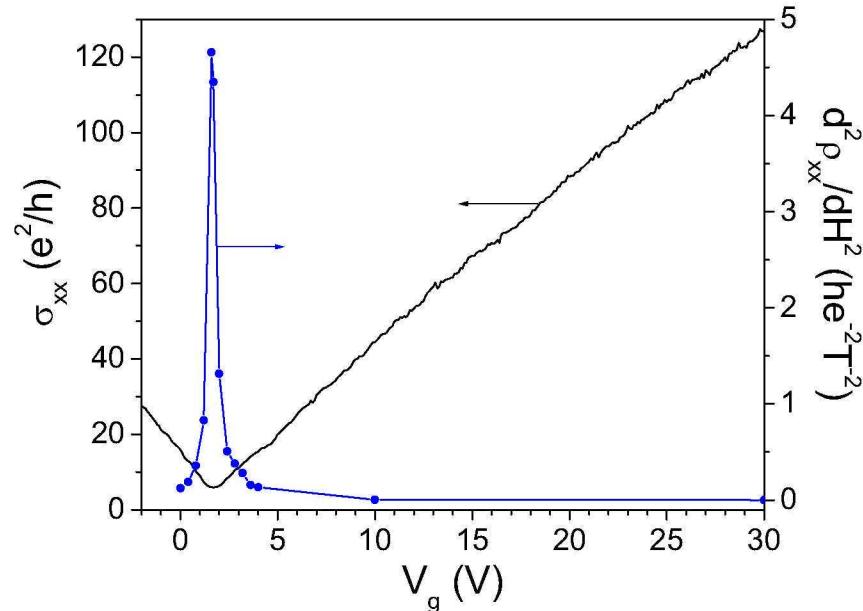
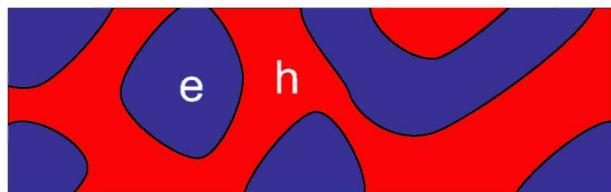
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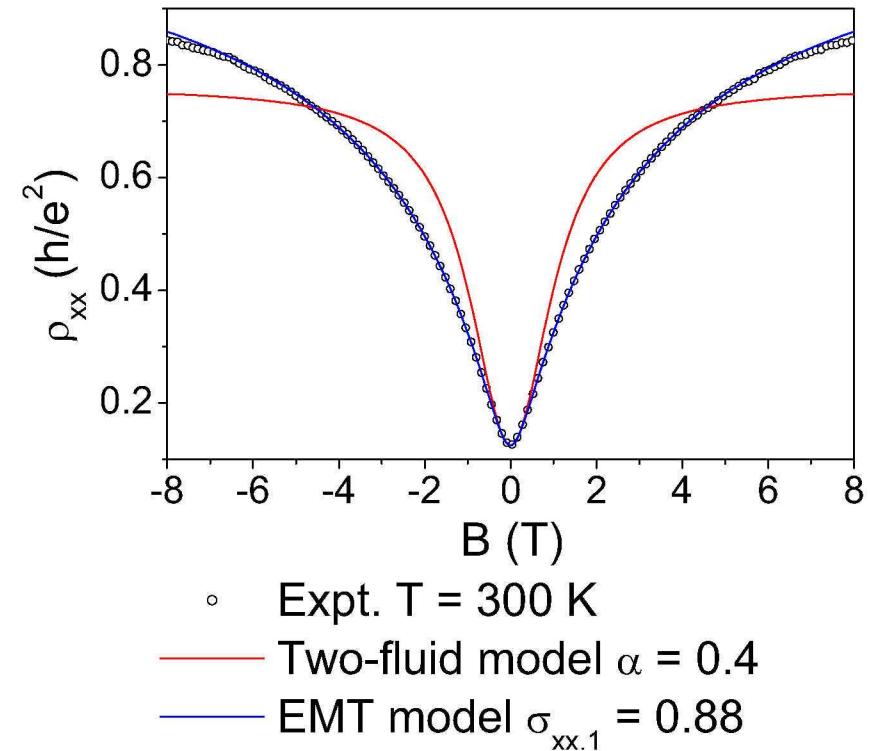
# Magnetoresistance at Minimum Conductivity Point

S. Cho and M. S. Fuhrer, *PRB* 77, 084102(R) (2008)

- At minimum conductivity point, graphene breaks into electron and hole “puddles”  
Hwang, et al., *PRL* 98, 186806 (2007); Adam, et al., *PNAS* 104, 18392 (2007)



Large spike in  
magnetoresistance at Dirac point

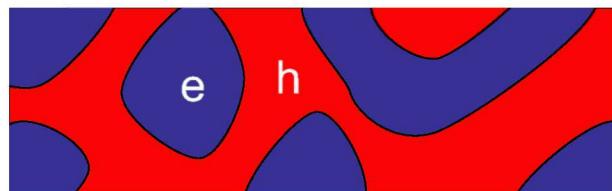


Functional form of  $\rho(B)$ :  
effective medium theory for  
inhomogeneous e/h regions  
[Guttal and Stroud, *PRB* 71 201304 (2005)]

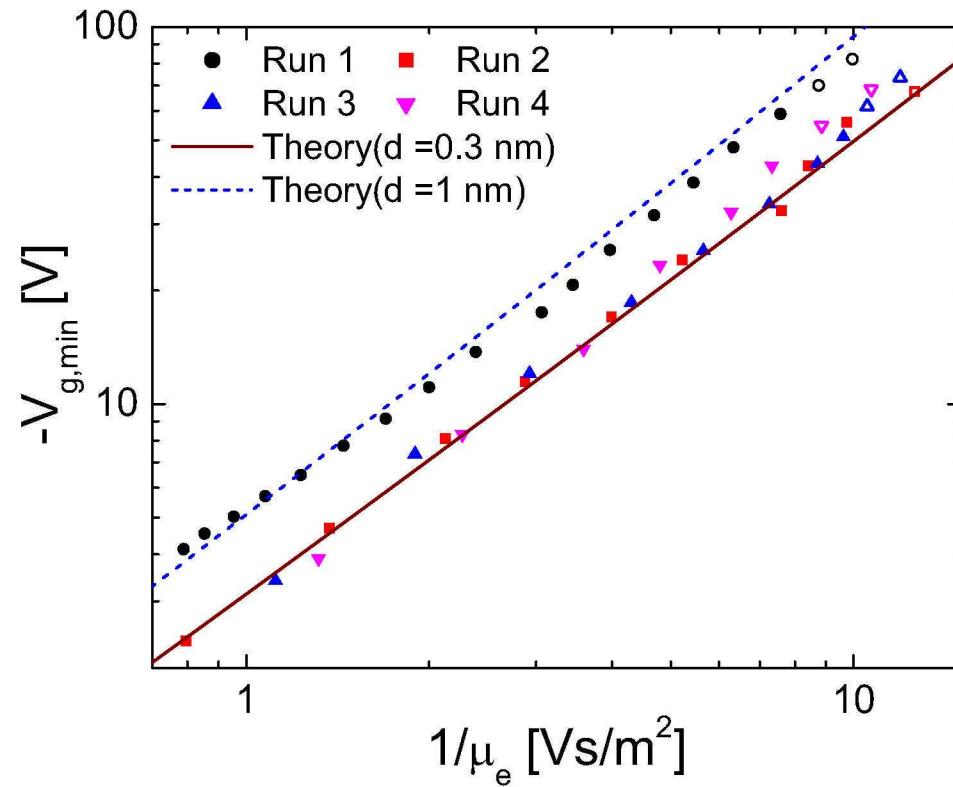
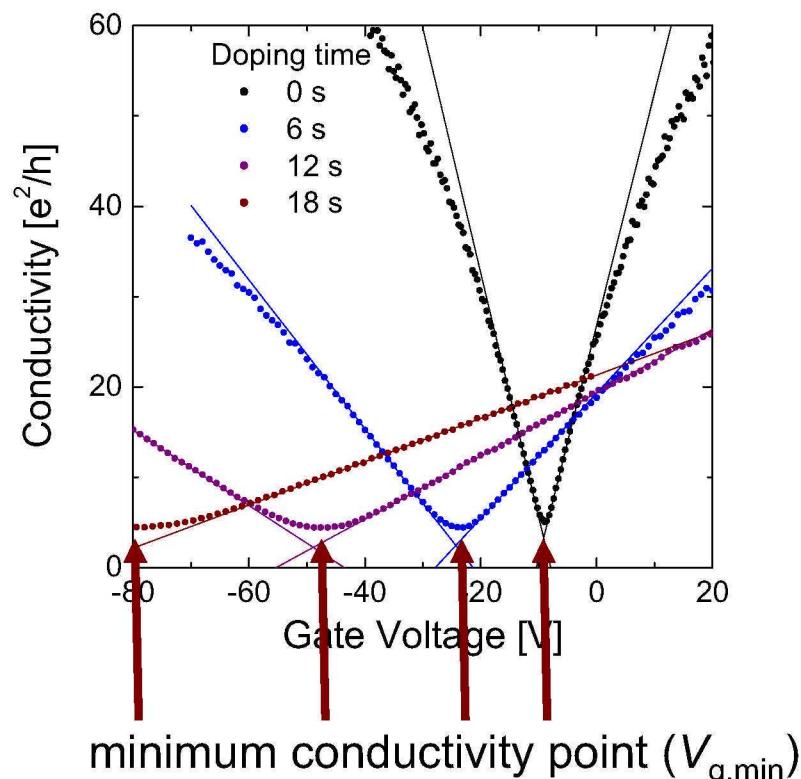
# Charged Impurity Scattering: Minimum Conductivity

J. H. Chen, et al. *Nature Physics* **4**, 377 (2008)

- At minimum conductivity point, graphene breaks into electron and hole “puddles”
- Minimum conductivity occurs when average screened potential is zero



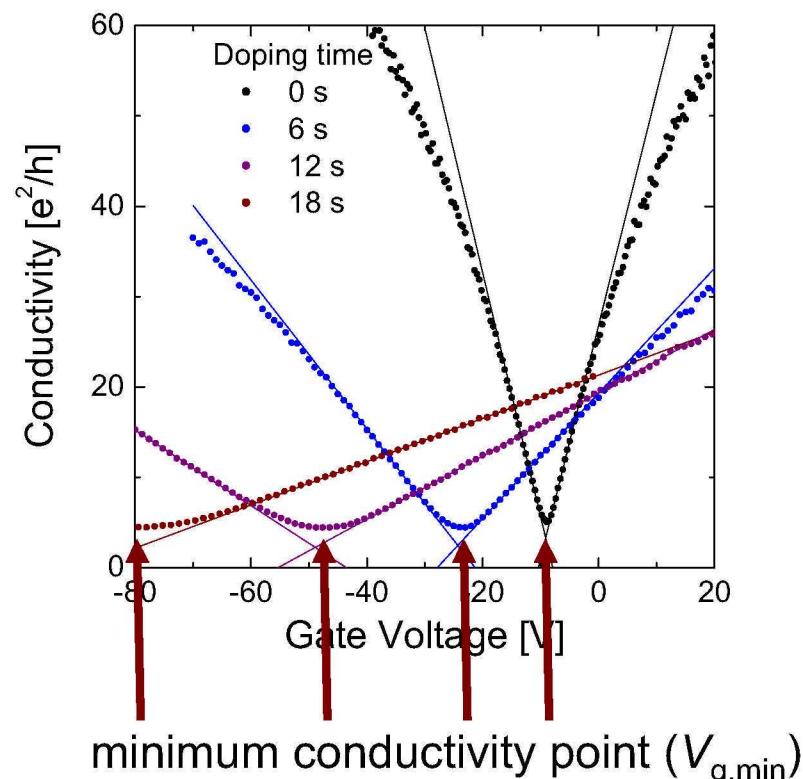
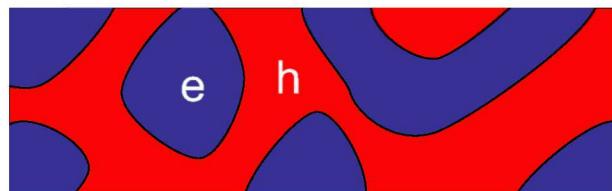
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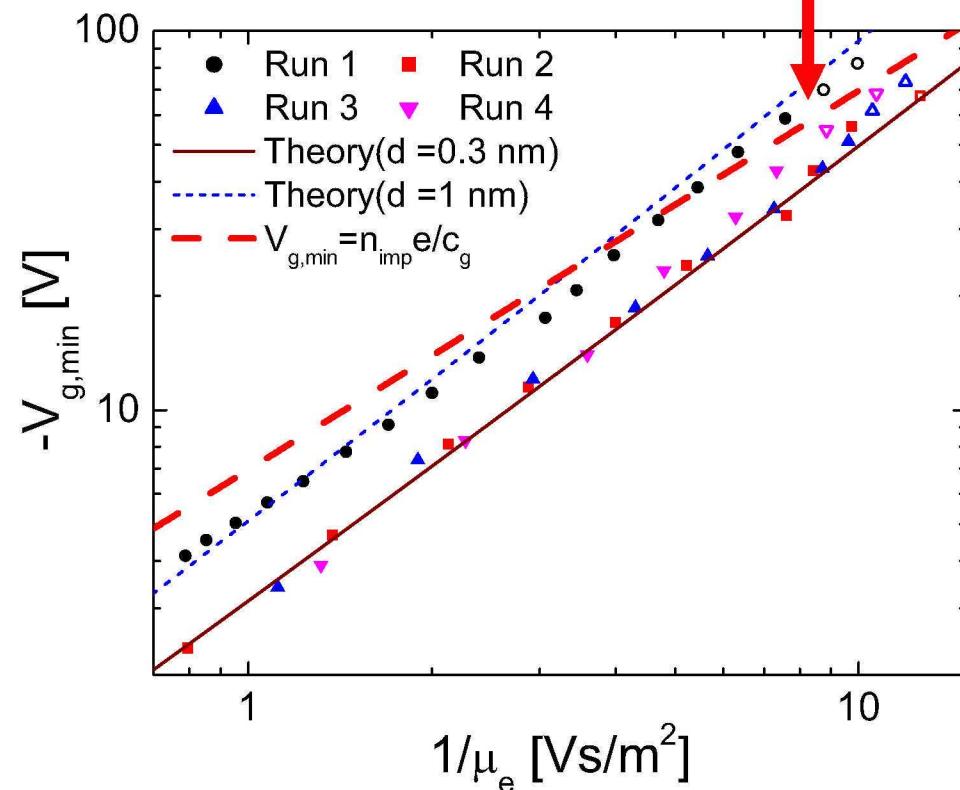
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“perfect screening”  
gate charge = impurity charge

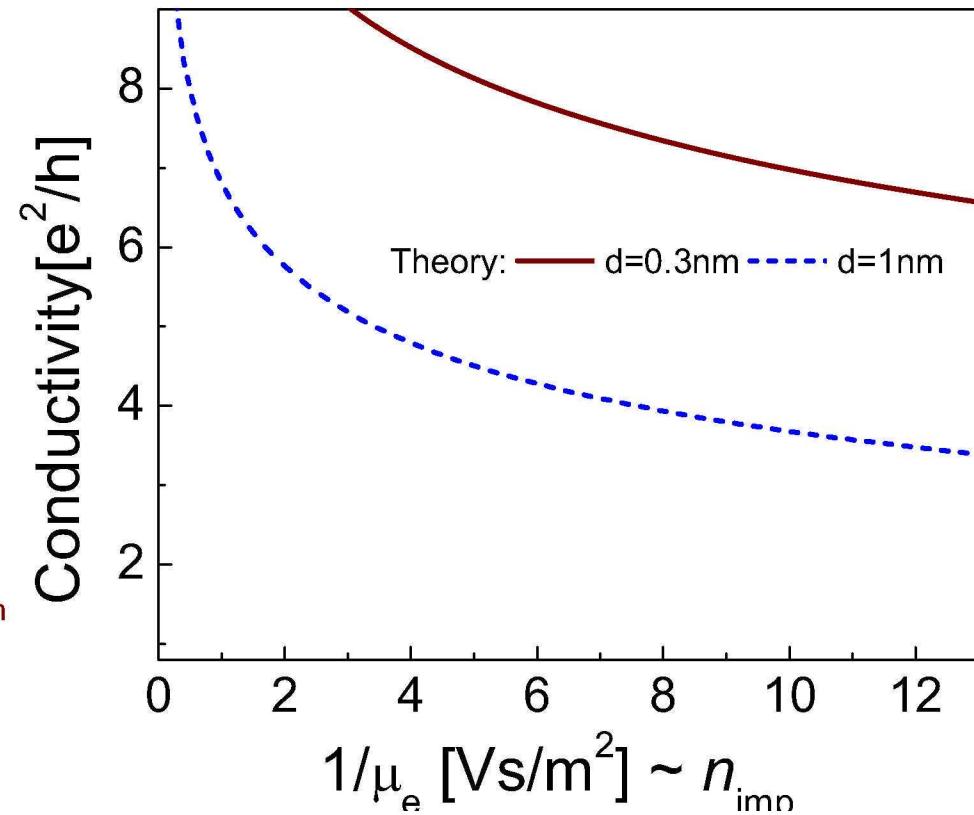
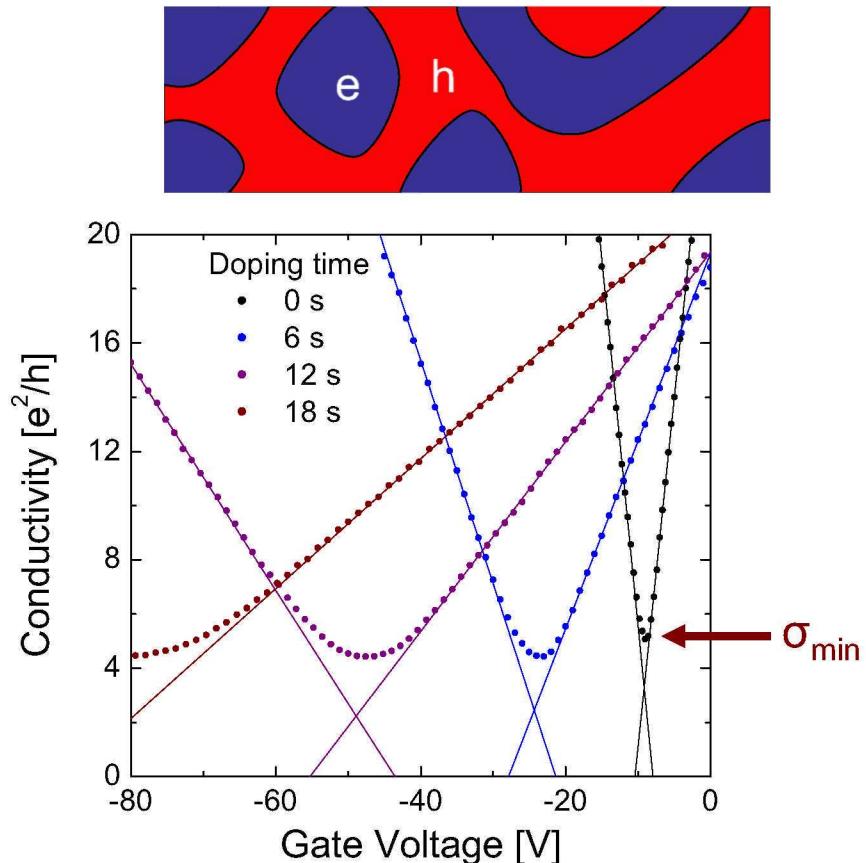


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Adam, et al., *PNAS* **104**, 18392 (2007)



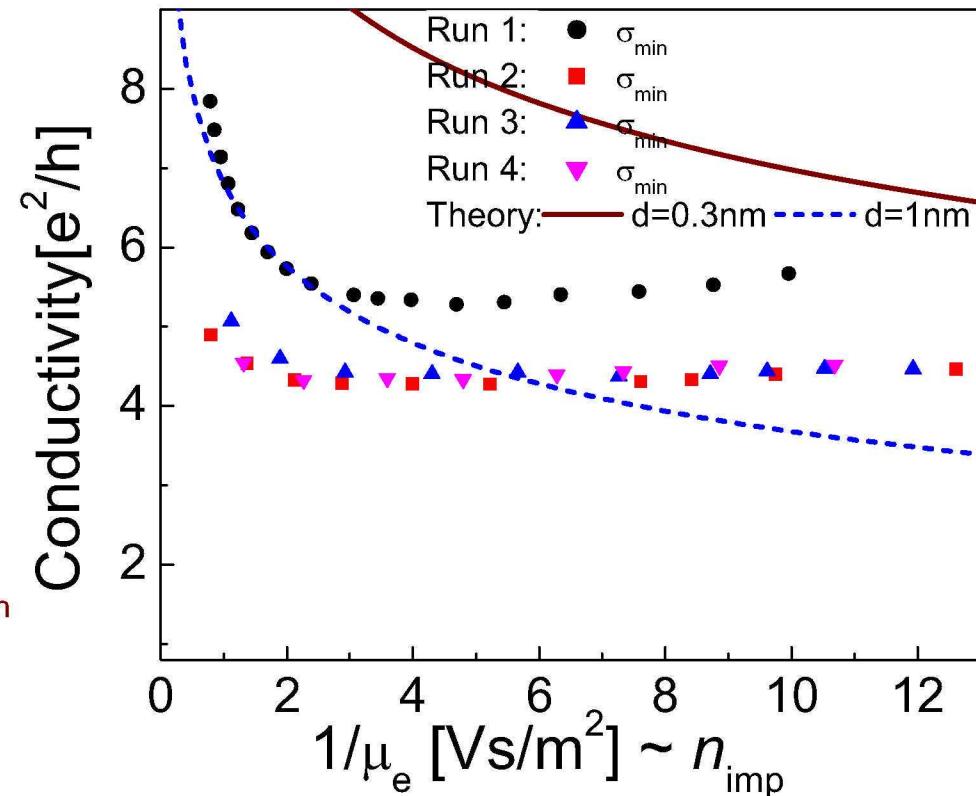
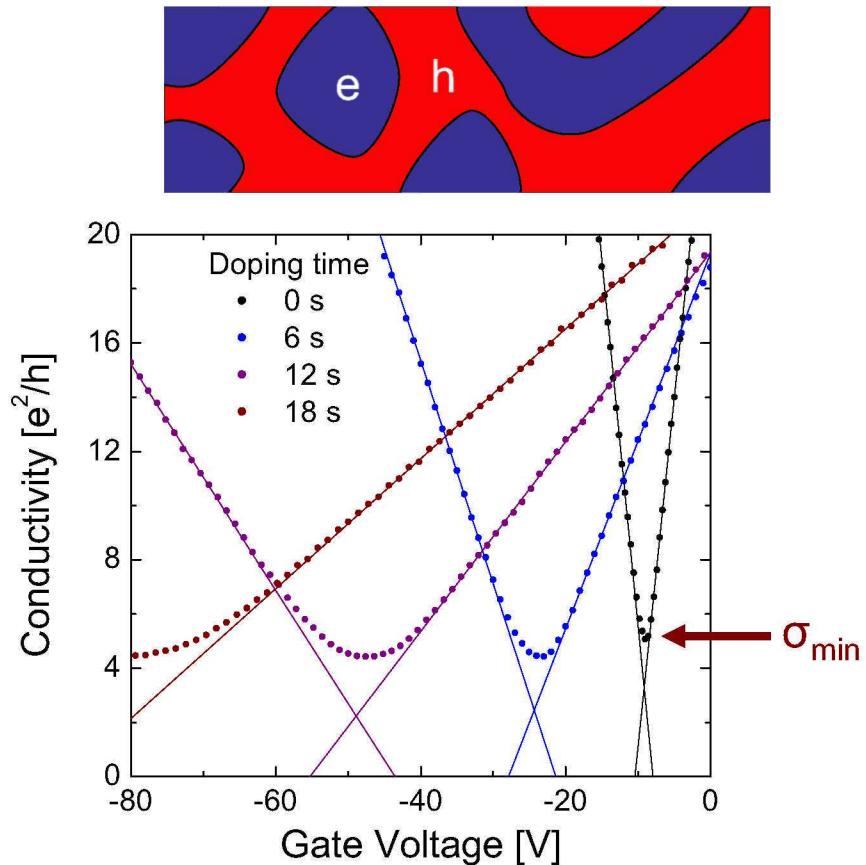
- Additional “residual conductivity” observed - extrapolation of linear  $\sigma(V_g)$
- Not theoretically understood [but see Trushin, PRL 99, 216602 (2007) and Yan, ArXiv:0708.1569]

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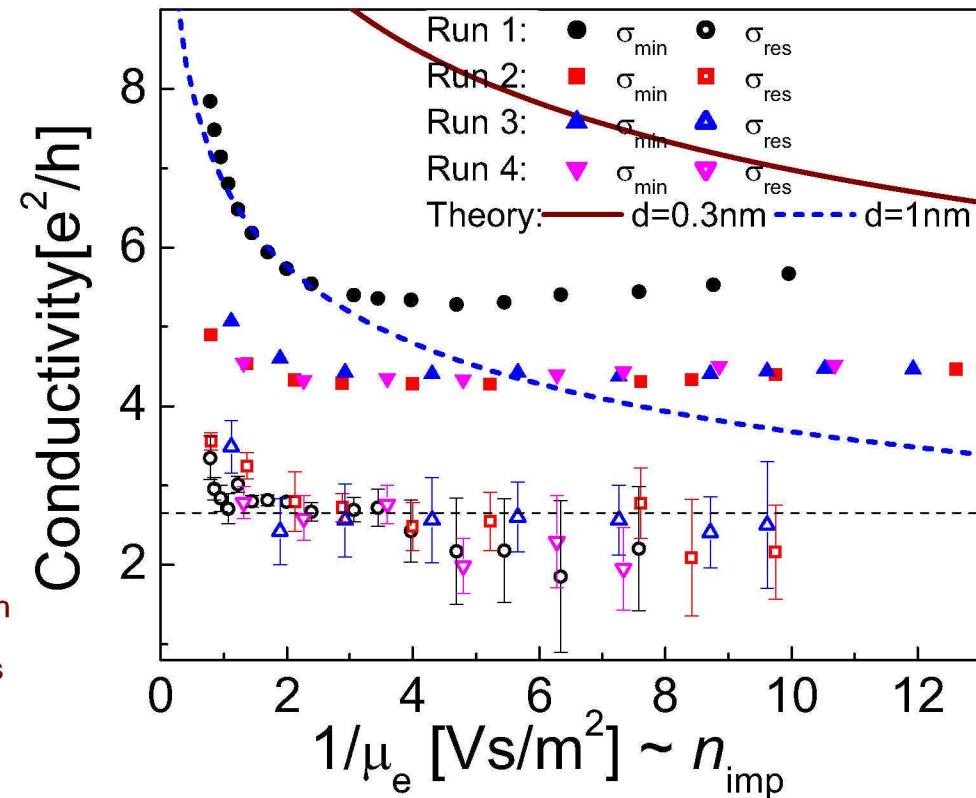
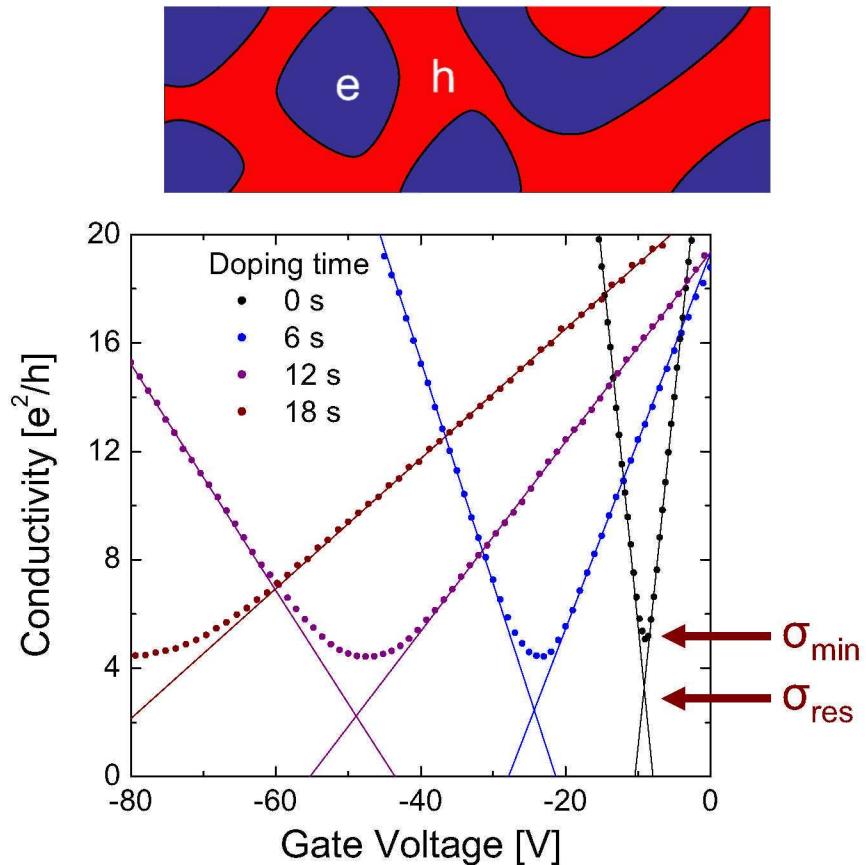
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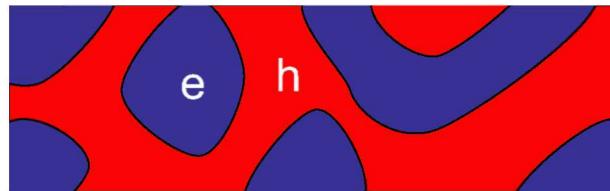
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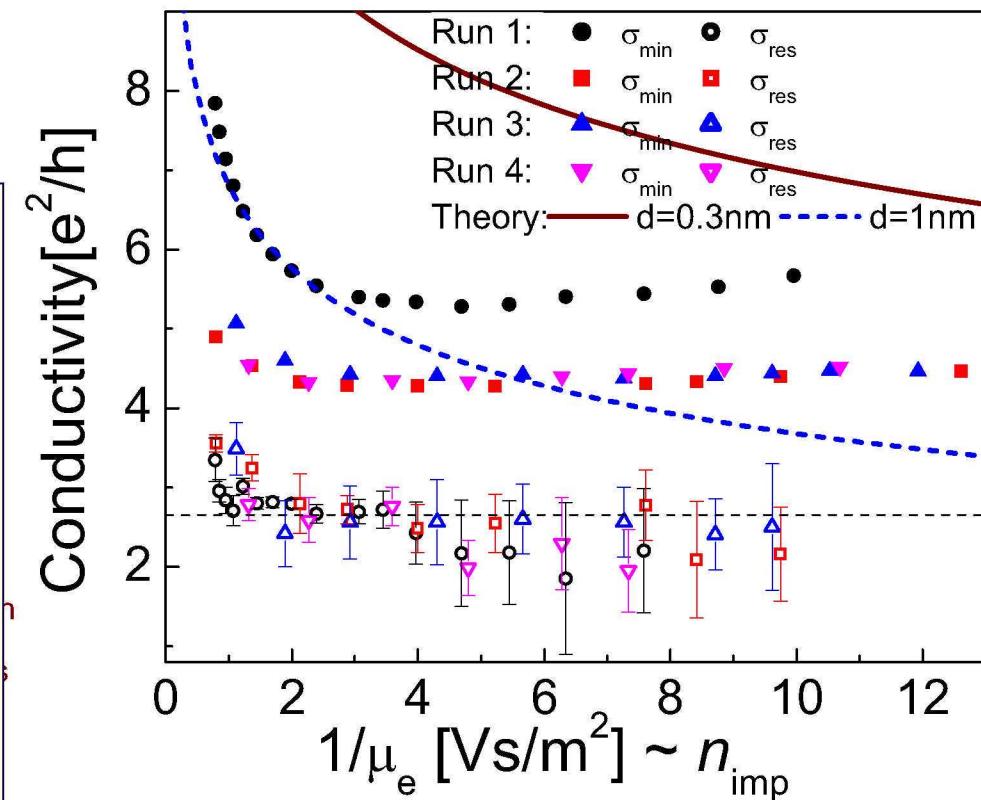


N.B.

$\sigma_{\min}$  decreases by factor of 1.5-2  
when disorder is *increased*

NOT effect of 4-probe geometry  
error (sample is same!)

NOT effect of macroscopic  
inhomogeneity (this would *increase*  
conductivity!)



- Additional “residual conductivity” observed - extrapolation of linear  $\sigma(V_g)$
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# Tuning the “Fine Structure Constant”

C. Jang, et al. ArXiv:0805.3780

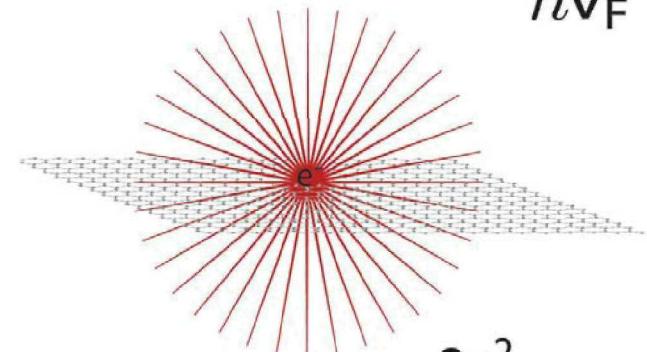
Dimensionless interaction strength

- $r_s \equiv \text{PE}/\text{KE}$

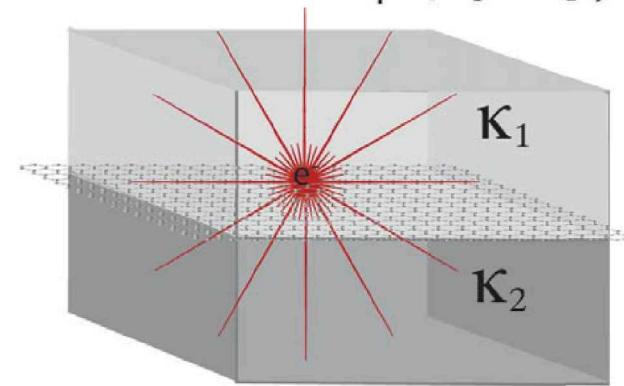
Graphene:

- $r_s = e^2/\hbar v_F = \alpha$  ( $c \rightarrow v_F$ )
- $\alpha$  is independent of carrier density in graphene
- Tunable through  $\kappa$  (dielectric constant of surroundings)

$$\alpha = \frac{e^2}{\hbar v_F}$$

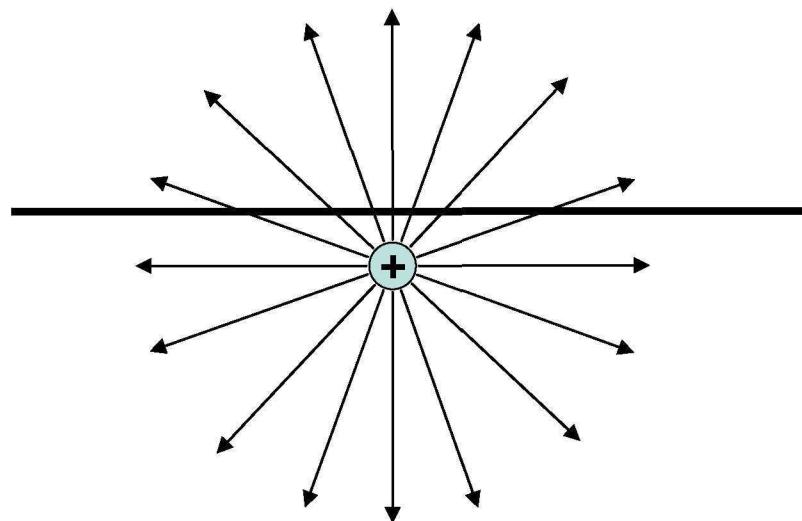


$$\alpha = \frac{2e^2}{\hbar v_F (\kappa_1 + \kappa_2)}$$



# How is an impurity screened?

Potential in 2d plane

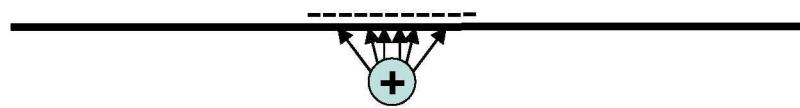


No screening:

$$V(q) = 2\pi e^2 \frac{e^{-qd}}{q}$$

# How is an impurity screened?

large screening (metal):

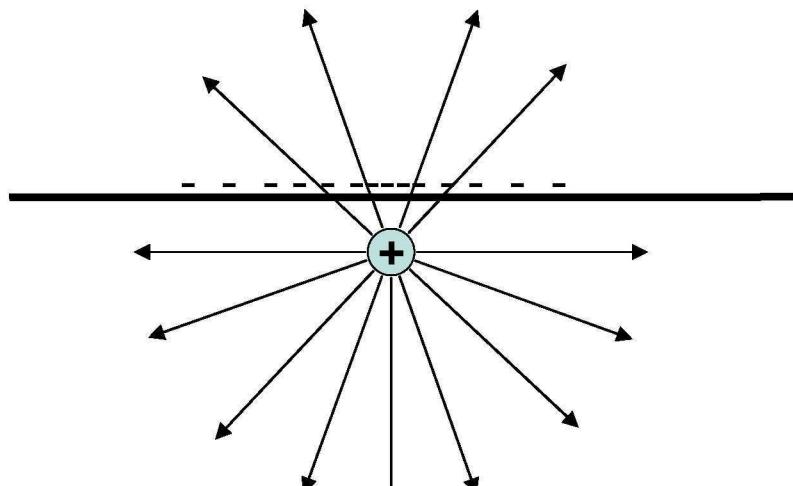


$$V(q) = 2\pi e^2 \frac{e^{-qd}}{q + q_s}$$

$$q_s \gg q$$

$q_s$  finite but large ( $\sim 1/a$ ):  
potential is short-range  
Confined to  $r \sim a$

Graphene  
 $k_F$ -dependent screening:



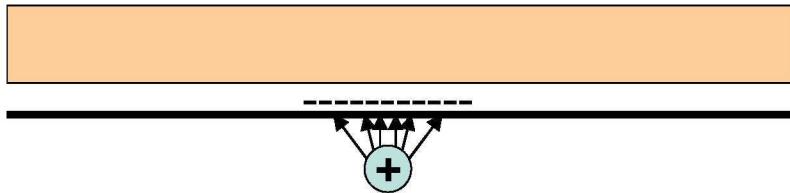
$$q_s = 4k_F r_s = \frac{4k_F e^2}{\kappa \hbar v_F}; \quad q \sim 2k_F$$

$$V(q) = 2\pi e^2 \frac{e^{-qd}}{k_F \left( 1 + \frac{2e^2}{\kappa \hbar v_F} \right)}$$

Long-range character remains for screened potential

# Adding a dielectric:

large screening (metal):



Dielectric cannot screen short-range (atomic scale) potential

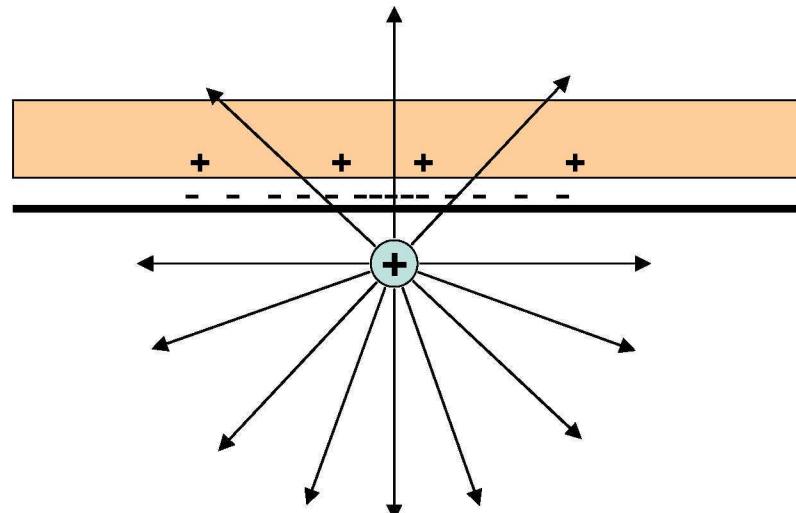
$$V(q) \approx 2\pi e^2 \frac{e^{-qd}}{q_s}$$

May change  $q_s$

Two effects:

- 1) Dielectric reduces field of screened impurity  $\rightarrow \mu$  increases
- 2) Dielectric reduces screening  $\rightarrow \mu$  decreases

Graphene  
 $k_F$ -dependent screening:



$$V(q) = \frac{2\pi e^2}{k_F} \frac{e^{-qd}}{\left(1 + 2 \frac{e^2}{\kappa \hbar v_F}\right)}$$

# Two Effects of Dielectric Screening

C. Jang, et al. ArXiv:0805.3780

Reducing  $\alpha$ :

- Reduces interaction of carriers with charged impurities
  - Dominant effect for charged-impurity scattering
- Reduces screening by carriers
  - Dominant effect for short-range scattering

Within RPA:

$$\sigma_L = \frac{2e^2}{h} \frac{n}{n_{imp}} \frac{1}{F_L(\alpha)}; \quad F_L(\alpha) = \pi\alpha^2 + \dots$$

Coulomb scattering reduced:  
**Mobility  $\mu_L$  increases**

$$\sigma_s = \frac{\sigma_0}{F_S(\alpha)}; \quad F_S(\alpha) = \frac{\pi}{2} - \frac{32\alpha}{3} + \dots$$

Short-range scattering increased:  
**Conductivity  $\sigma_s$  decreases**

$$\sigma_{min} = n^* e \mu_L; \quad n^* \sim \alpha^2; \quad \mu_L \sim \frac{1}{\alpha^2}$$

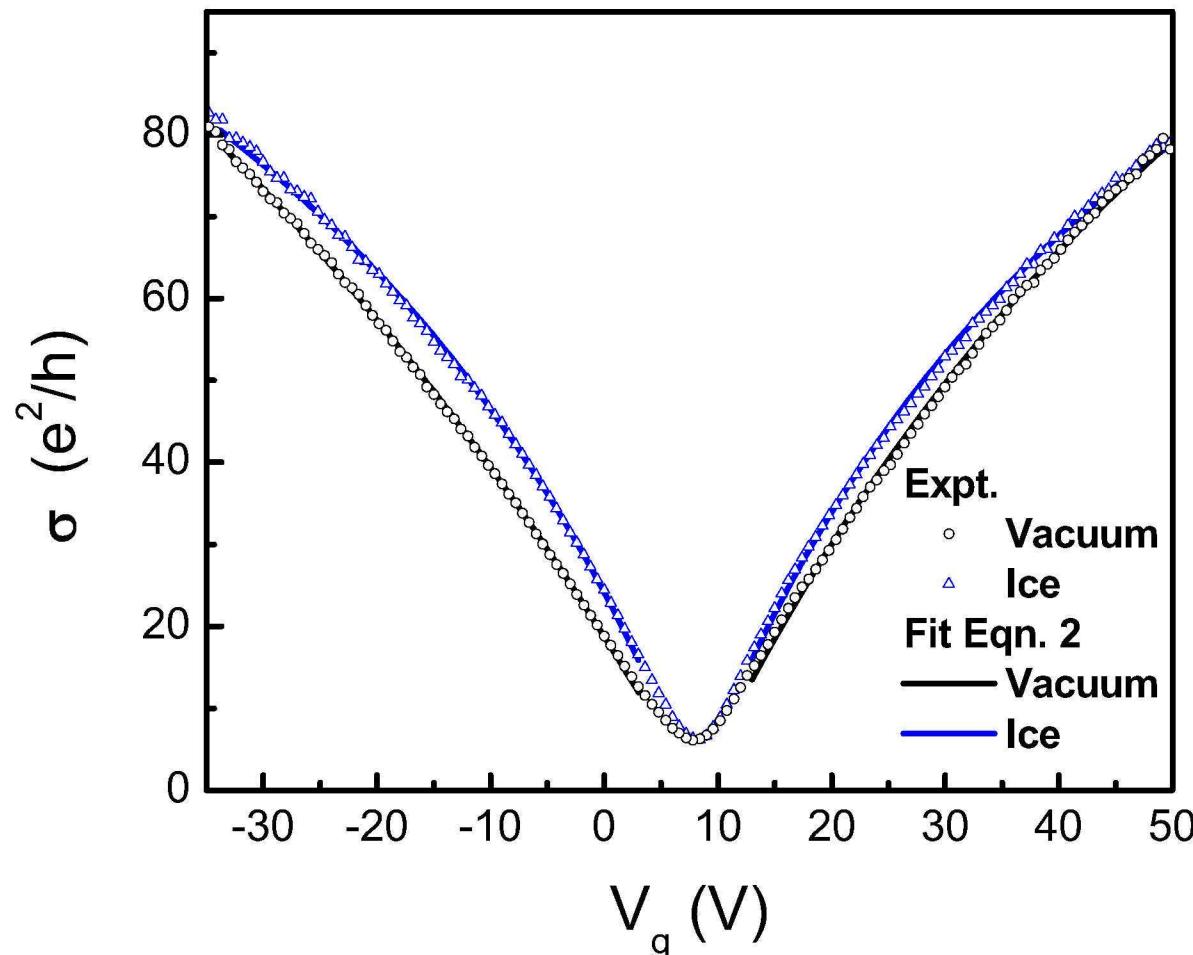
e-h puddle density decreased,  
mobility increased:  
**Min. conductivity  $\sigma_{min}$  constant**

# Effects of Dielectric Screening

C. Jang, et al. ArXiv:0805.3780

Add ice to clean graphene in UHV:

$$\alpha(\text{SiO}_2/\text{vacuum}) = 0.81 \quad \alpha(\text{SiO}_2/\text{ice}) = 0.56$$



Fit:

$$\sigma^{-1} = (ne\mu_L)^{-1} + \sigma_S^{-1}$$

Coulomb (long-range)  
scattering

Short-range scattering

(slight asymmetry in  
Coulomb scattering;  
take symmetric  
component of each)

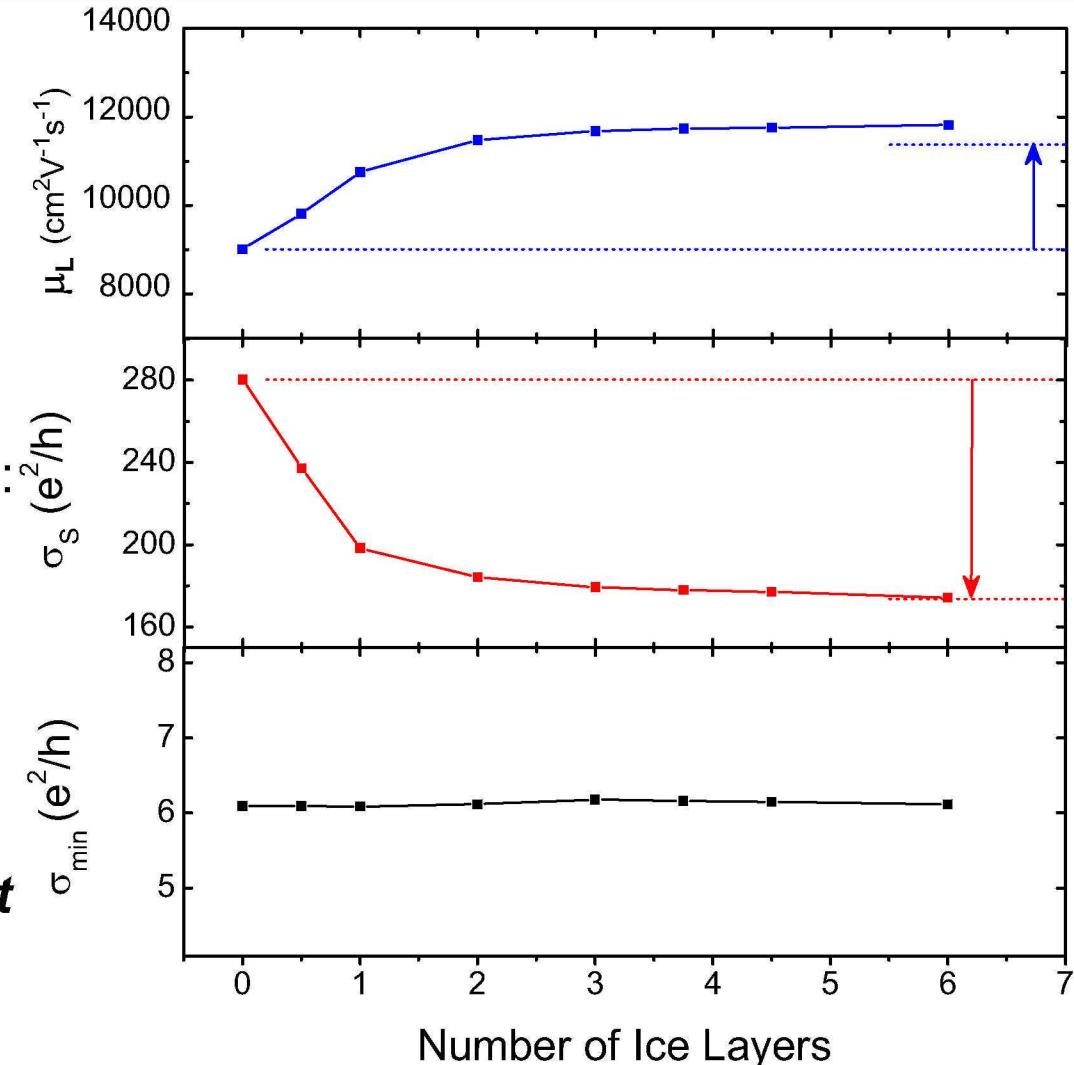
# Dielectric Screening: Theory and Expt.

C. Jang, et al. ArXiv:0805.3780

Coulomb scattering reduced:  
**Mobility  $\mu_L$  increases**

Short-range scattering increased:  
**Conductivity  $\sigma_s$  decreases**

e-h puddle density decreased,  
mobility increased:  
**Min. conductivity  $\sigma_{\min}$  constant**



# Dielectric Screening: Theory and Expt.

C. Jana. et al. ArXiv:0805.3780

N.B. There are NO fitting parameters here!

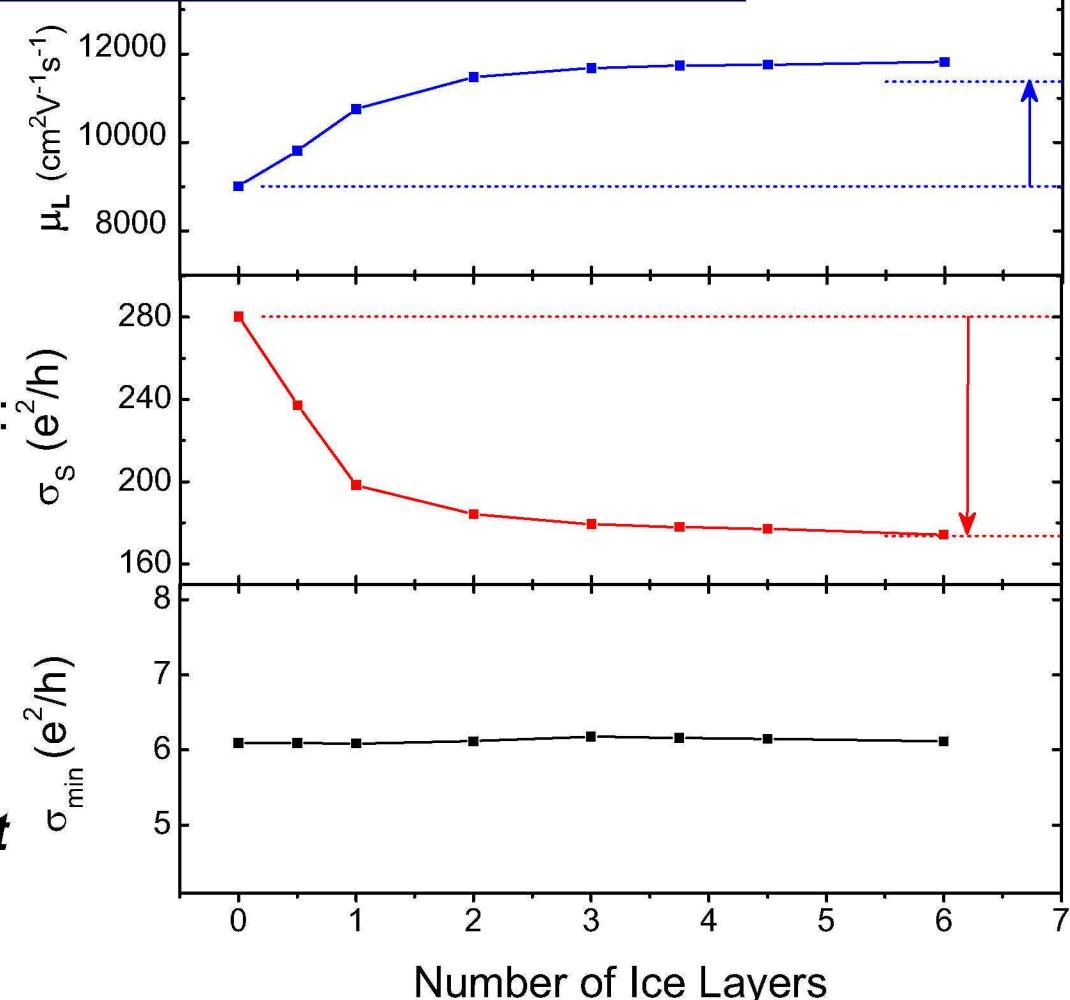
Coulomb scattering reduced:  
**Mobility  $\mu_L$  increases**

N.B. Mobility increases 30% for  
 $\kappa_{\text{avg}}$ : 2.45 → 3.55

Short-range scattering increased:  
**Conductivity  $\sigma_s$  decreases**

N.B.  $\sigma_s$  decreases 40% for  
 $\kappa_{\text{avg}}$ : 2.45 → 3.55

e-h puddle density decreased,  
mobility increased:  
**Min. conductivity  $\sigma_{\min}$  constant**



# Outline

- I. Introduction to Graphene
  - “Massless” electrons
  - Pseudospin and Berry’s phase
- II. Fabrication and Characterization of Graphene on SiO<sub>2</sub>
  - Micro-Raman spectroscopy
  - Scanning Tunneling Microscopy
- III. Diffusive Transport in Graphene
  - Boltzmann Transport
    - Charged impurities
    - Effect of Dielectric Environment
    - Corrugations
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  - Fabry-Perot Interference → Density of States

# Graphene Corrugation - Scattering

$$\sigma = \frac{2e^2}{h} E_F \tau \quad \frac{1}{\tau} \propto \frac{2\pi}{\hbar} \left| \langle k | V | k' \rangle \right|^2 D(E) \quad q\text{-dependent interaction} \\ \rightarrow \text{carrier-density dependent } \sigma(n)$$

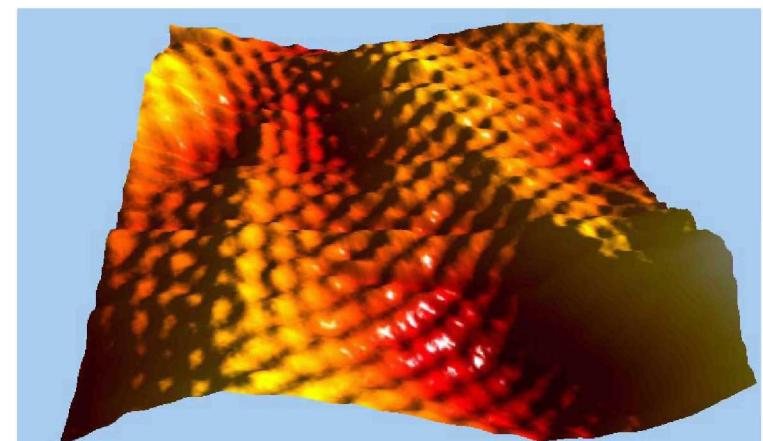
1) Coulomb interaction:  $q = |\mathbf{k} - \mathbf{k}'| \sim k_F \implies \sigma \sim n$

2) Corrugated graphen<sup>t</sup>:  $\langle [h(r) - h(0)]^2 \rangle \propto r^{2H} \implies \sigma \sim n^{2H-1}$

height-height correlation function

<sup>t</sup>Katsnelson & Geim, *Phil. Trans. R. Soc. A*  
**366**, 195-204 (2008)

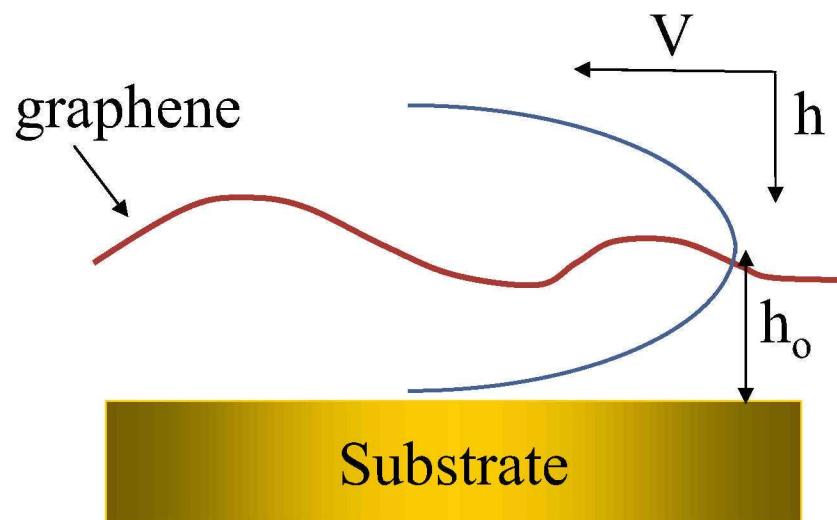
What is exponent  $2H$ ?



# Graphene Corrugation

## Model 1:

Intrinsic graphene bending constrained via interface confining potential



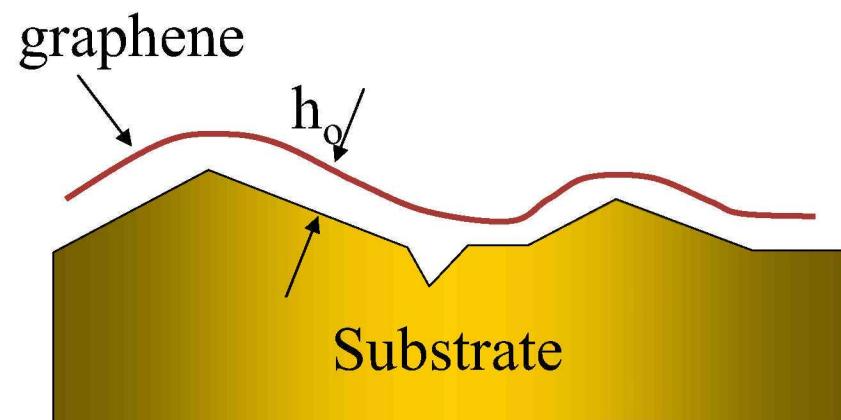
$$F = \frac{1}{2} \kappa [\nabla^2 h(x, y)]^2 + \frac{1}{2} V h^2(x, y)$$

$$\langle (h(r) - h(0))^2 \rangle \sim r^2$$

$\sigma(n) \sim n$   
(mimics Coulomb scattering)

## Model 2:

Corrugations determined by strong direct interaction governed by height variations of the substrate



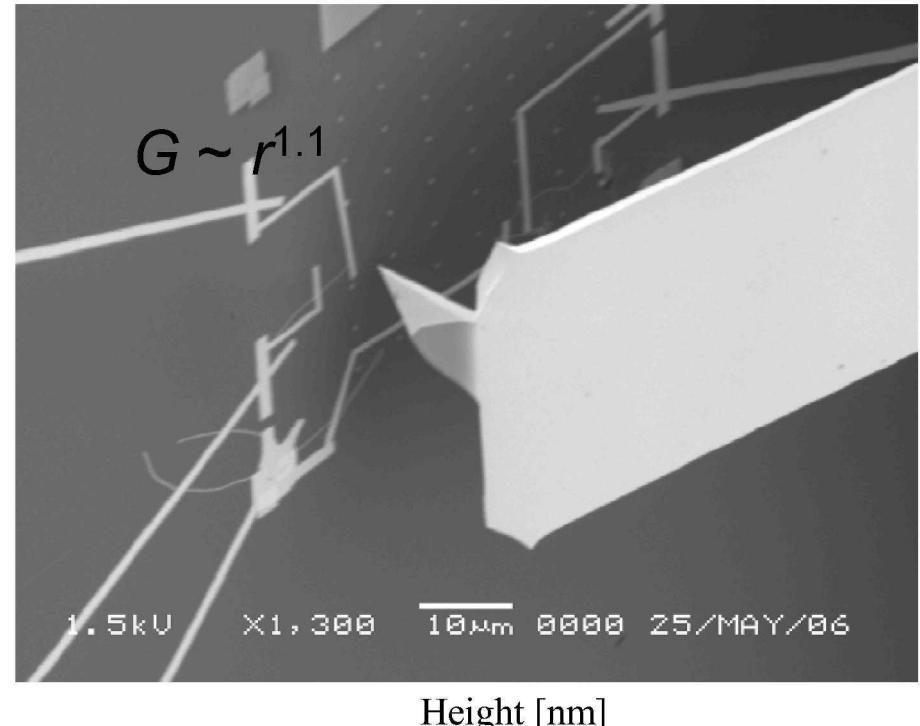
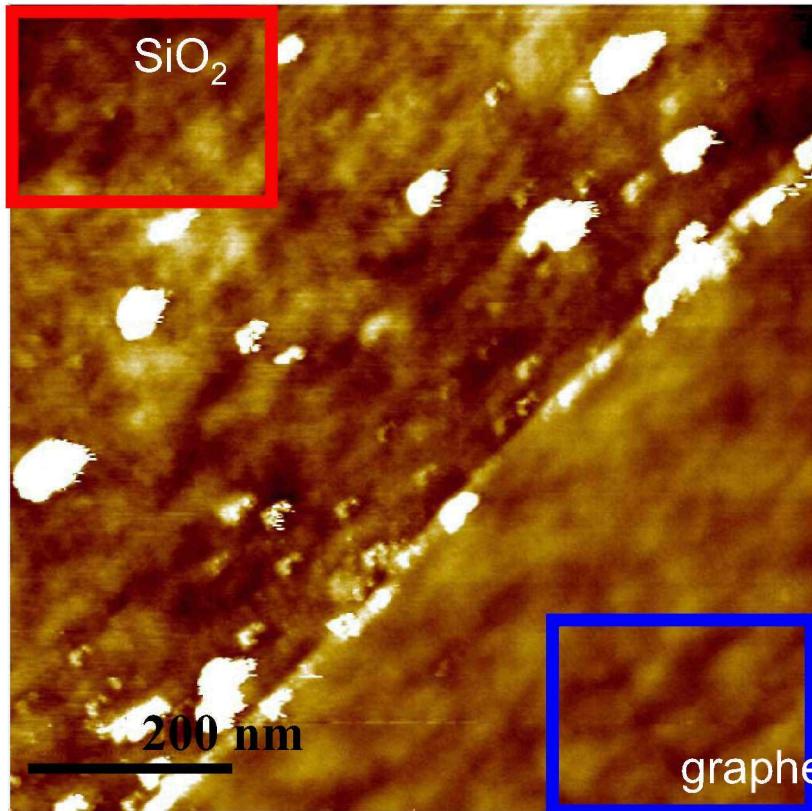
Height-height correlations will match those of the substrate.

Typical non-equilibrium surfaces show:  $\langle (h(r) - h(0))^2 \rangle \sim r^{2H}$   
with  $2H \approx 1$ .

$\sigma(n) \sim \text{constant}$   
(mimics short range scattering)

# Graphene Corrugations on SiO<sub>2</sub>

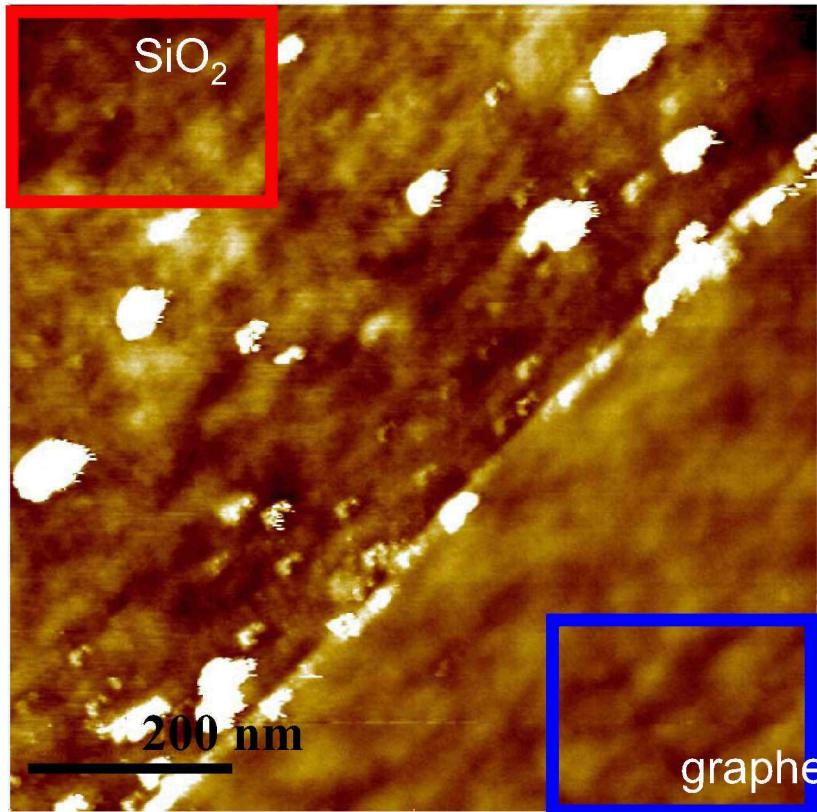
Non-contact AFM image in UHV



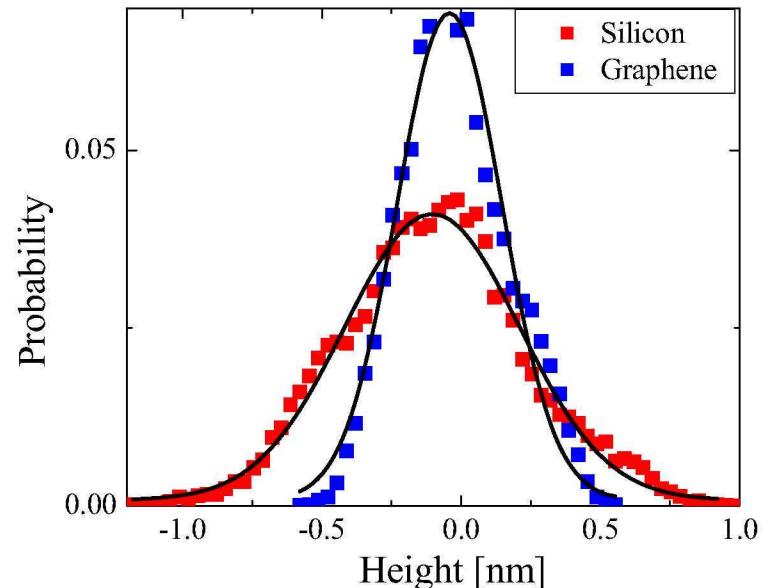
M. Ishigami et al., *Nano Letters* 7, 1643 (2007)

# Graphene Corrugations on SiO<sub>2</sub>

Non-contact AFM image in UHV



Oxide-graphene boundary

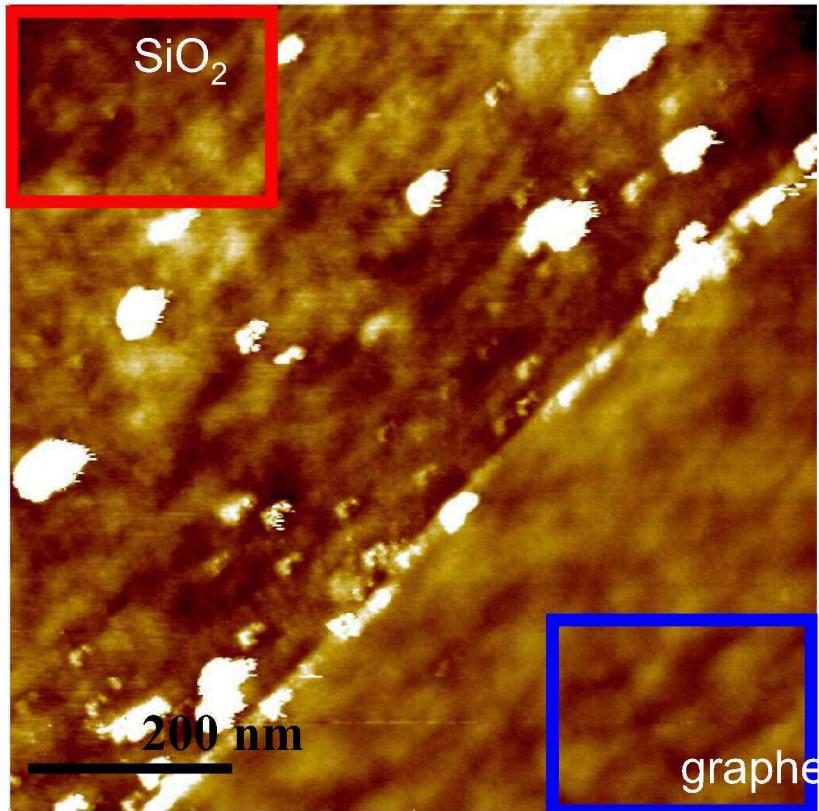


- $\sigma_{\text{oxide}} = 3.1 \text{ \AA}$  and  $\sigma_{\text{graphene}} = 1.9 \text{ \AA}$
- Graphene 60% smoother than SiO<sub>2</sub>

M. Ishigami et al., *Nano Letters* 7, 1643 (2007)

# Graphene Corrugations on SiO<sub>2</sub>

Non-contact AFM image in UHV

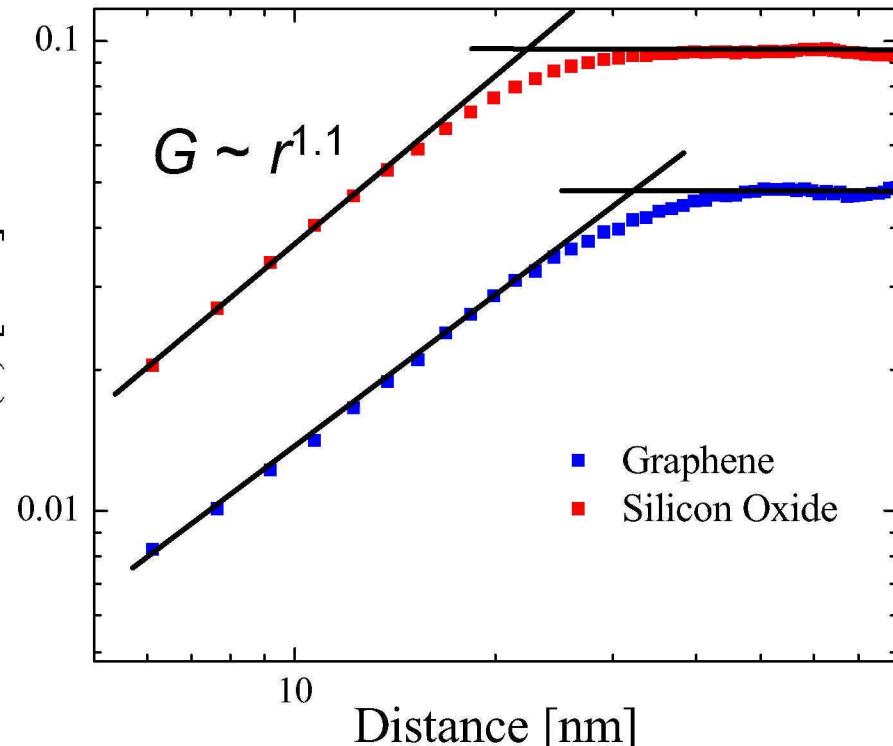


Oxide-graphene boundary

Height-height correlations function

$$\langle (h(r) - h(0))^2 \rangle \sim r^{2H}$$

with  $2H \approx 1$



$\sigma(n) \sim \text{constant}$   
(mimics short range scattering)

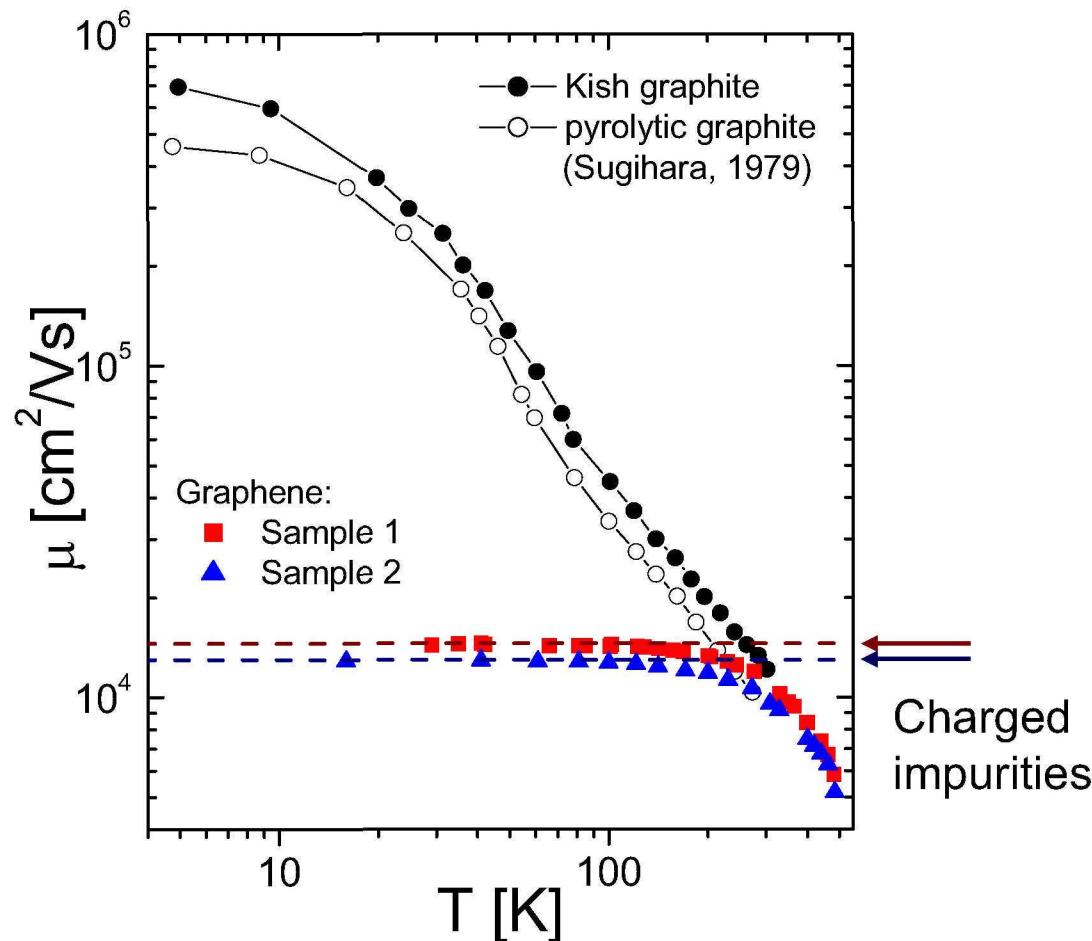
M. Ishigami et al., *Nano Letters* 7, 1643 (2007)

# Outline

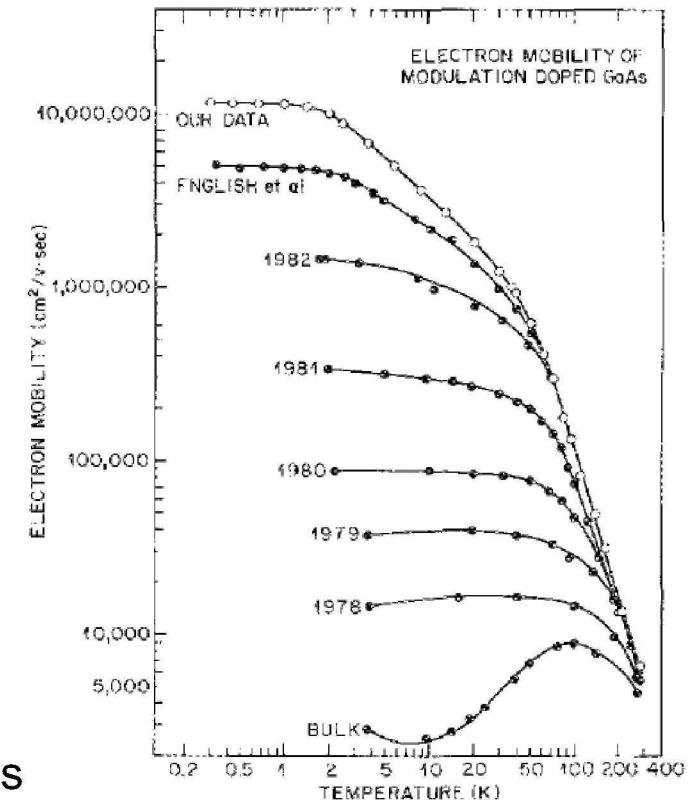
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# Limits of Mobility in Graphene

Bulk Graphite  
and Graphene on  $\text{SiO}_2$



GaAs (Pfeiffer and West, 1989)



# Electron-Phonon Scattering

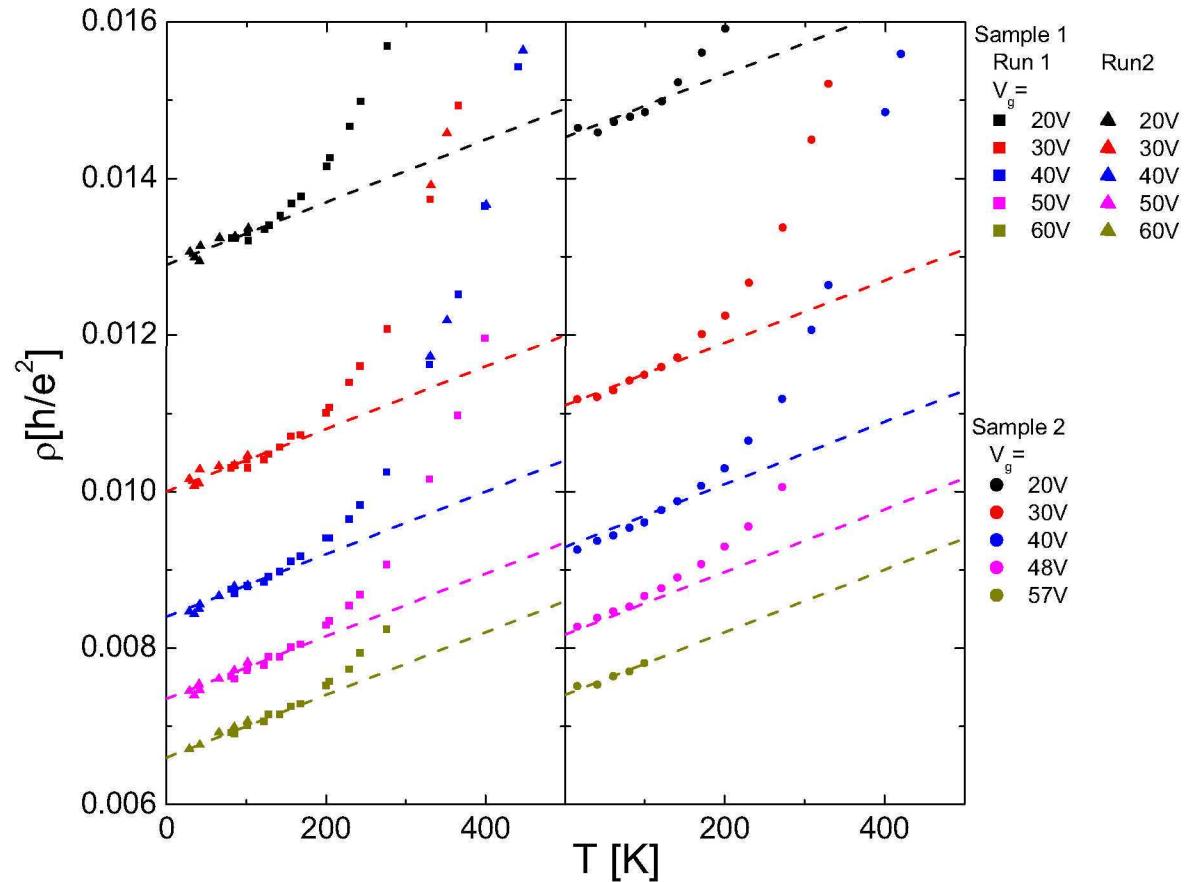
J. H. Chen, et al. *Nature Nanotechnology* 3, 206 (2008)

Linear  $T$ -dependence  
at low  $T$

Longitudinal acoustic  
phonons in graphene

$$\rho = \rho_0 + AT$$
$$A = 0.1 \Omega/K$$

$A$  is independent of  
charge carrier density, as  
predicted



$$\rho_A(T) = \left( \frac{h}{e^2} \right) \frac{D_A^2 k_B T}{16 e^2 \hbar^2 \rho_s v_s^2 v_F^{-2}}$$

$$\rightarrow D_A = 18 \pm 1 \text{ eV}$$

(good agreement w/CNT, graphite)

# Electron-Phonon Scattering

J. H. Chen, et al. *Nature Nanotechnology* 3, 206 (2008)

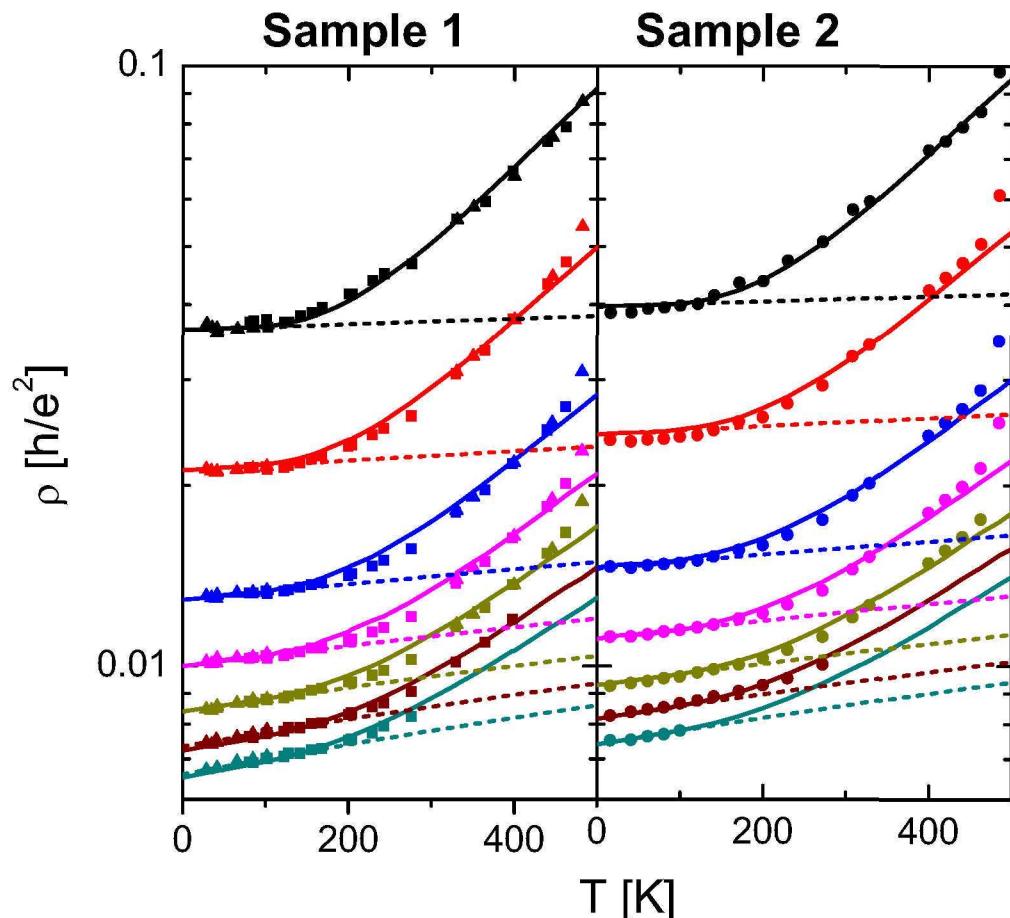
**Activated  $T$ -dependence at high  $T$**

Consistent with:

*LA phonons in graphene*

$$\rho(n, T) = \rho_0 + AT + Bn^{-\alpha} \left( \frac{1}{e^{(59\text{meV})/k_B T} - 1} + \frac{6.5}{e^{(155\text{meV})/k_B T} - 1} \right)$$

*polar optical surface phonons in  $\text{SiO}_2$*   
(see Fratini and Guinea, ArXiv:0711.1303)



(3 global fit parameters for all curves)

Potential due to polar optical phonons is long-ranged; leads to density-dependent resistivity

# Mobility Limits in Graphene

J. H. Chen, et al. *Nature Nanotechnology* 3, 206 (2008)

Room Temperature Limits:

Currently:

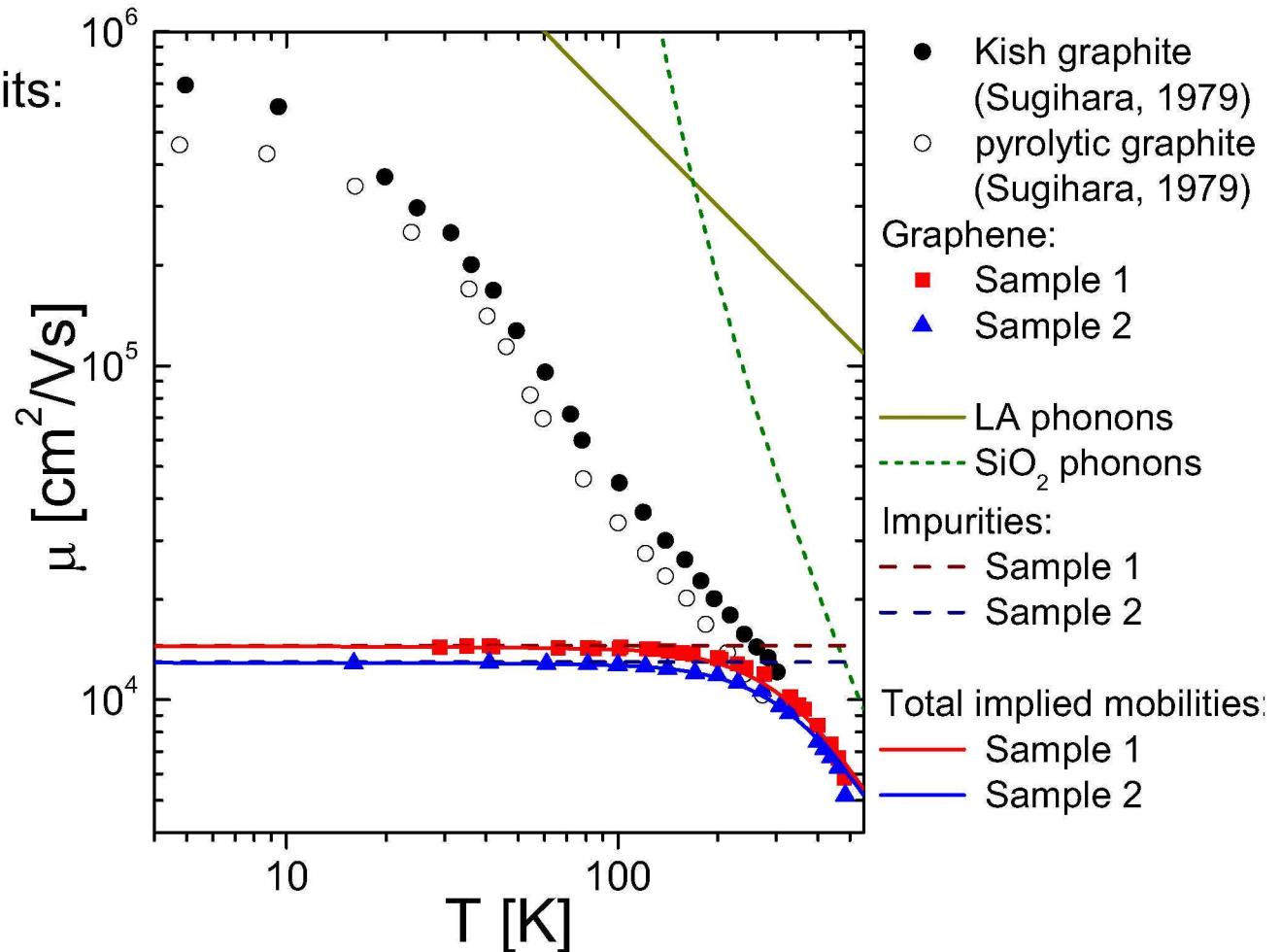
$\mu_{RT} \sim 10^4 \text{ cm}^2/\text{Vs}$   
(charged impurities)

Substrate-limited:

$\text{SiO}_2$  surface phonons:  
 $\mu_{RT} \sim 4 \times 10^4 \text{ cm}^2/\text{Vs}$

Intrinsic:

acoustic phonons:  
 $\mu_{RT} \sim 2 \times 10^5 \text{ cm}^2/\text{Vs}$   
@  $n = 10^{12} \text{ cm}^{-2}$



Room temperature mobility of **200,000 cm<sup>2</sup>/Vs** possible!

Ballistic transport over >2 microns

# Suspended Graphene (Kim group, Columbia)

Kim, Stormer et al. (Columbia U.)

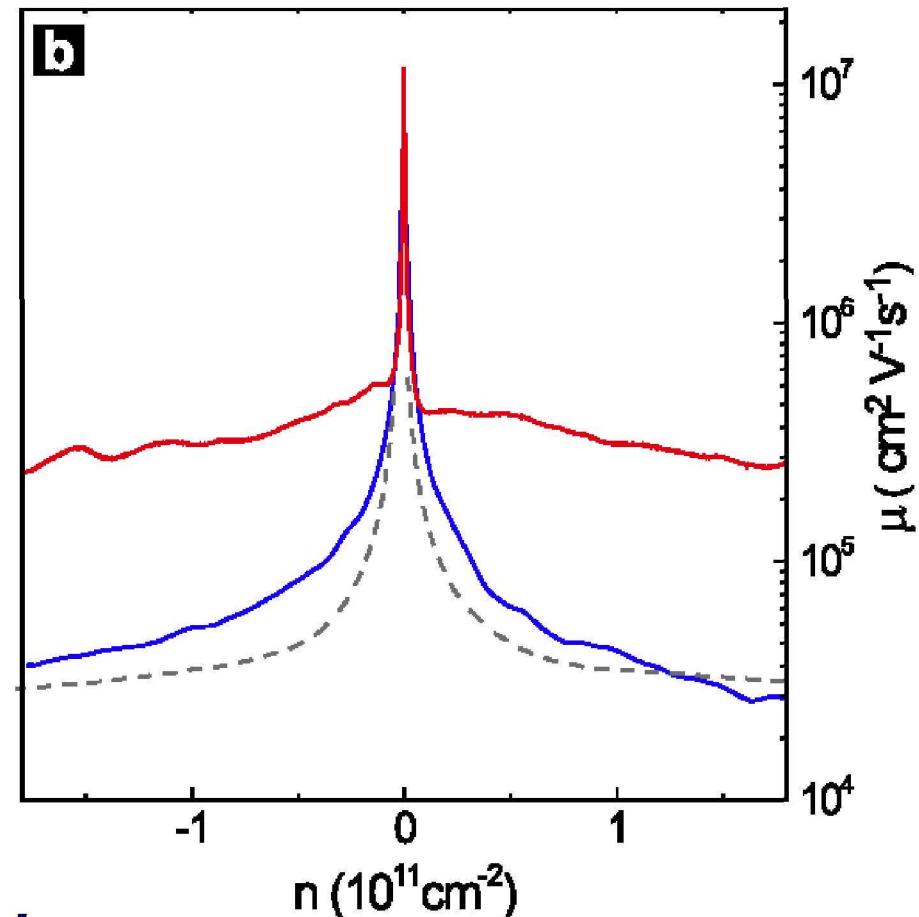
Solid State Comm. 146, 351-355 (2008),  
arXiv:0805.1830

Suspended graphene:

- >10x increase in mobility
- 230,000 cm<sup>2</sup>/Vs ( $T = 5$  K)
- 120,000 cm<sup>2</sup>/Vs ( $T = 240$  K)

Removing substrate:

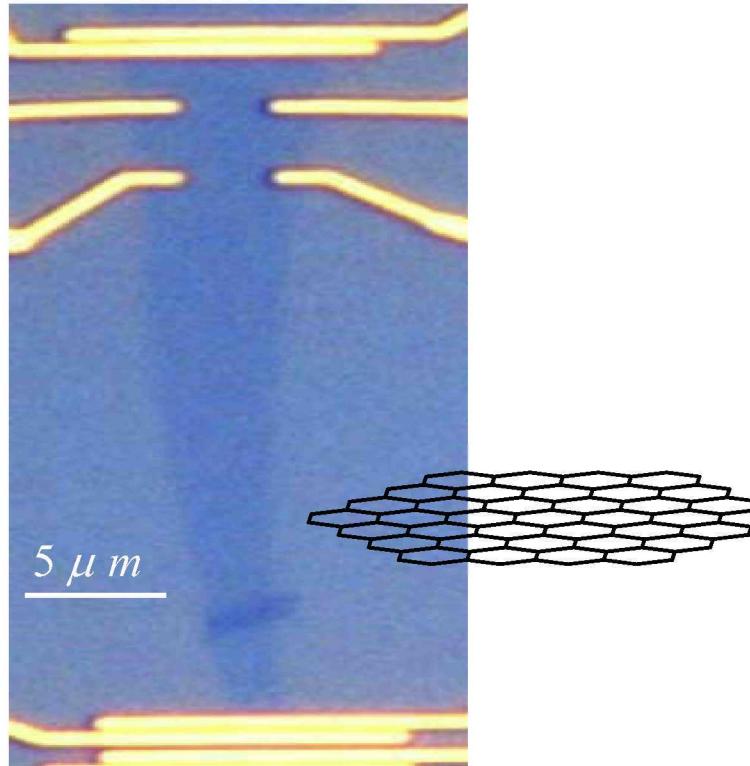
- Removes charged impurities***
- Removes RIP phonon scattering***



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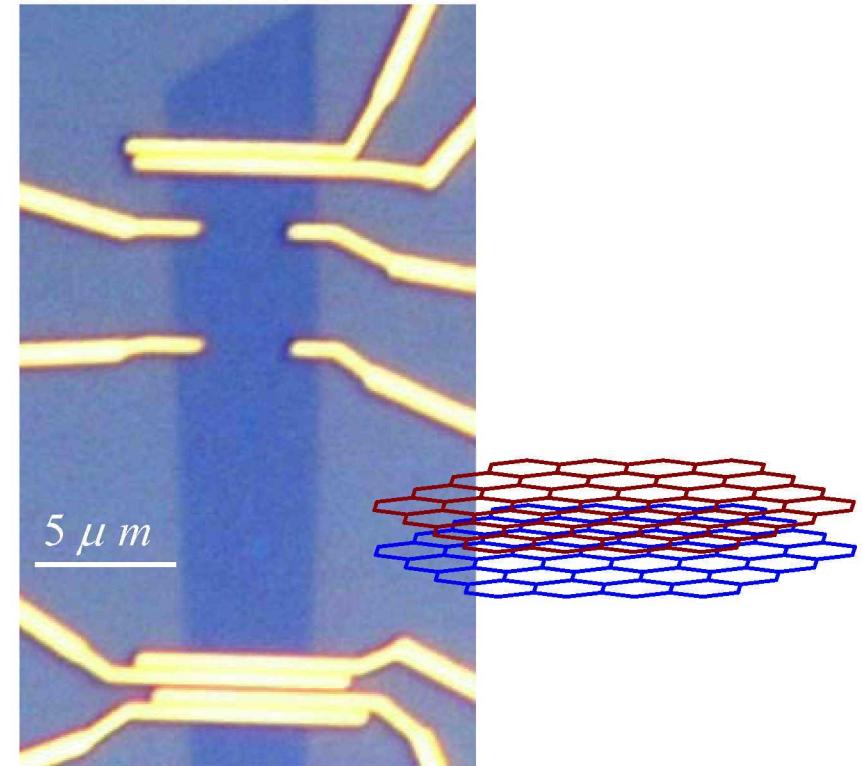
# Graphene: Single layer vs. Bilayer



Single layer Graphene

$$w = 6.0 \mu m$$

$$l = 2.6 \mu m$$

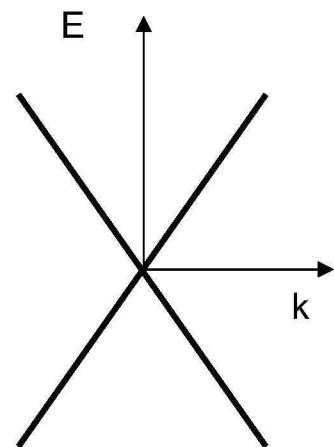
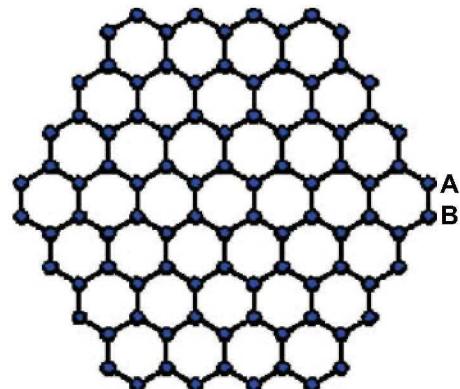


Bilayer Graphene

$$w = 5.2 \mu m$$

$$l = 4.3 \mu m$$

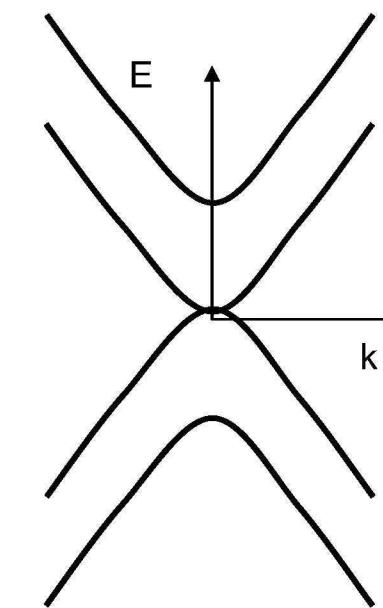
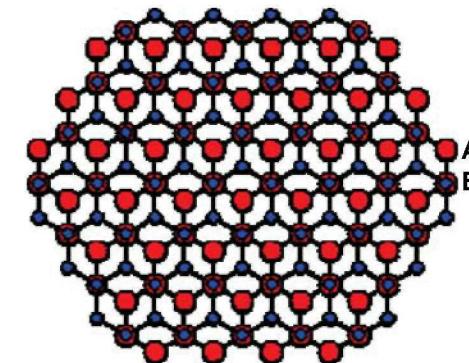
# Bilayer Dispersion Relation



$$E = \hbar v_F |\mathbf{k}|$$

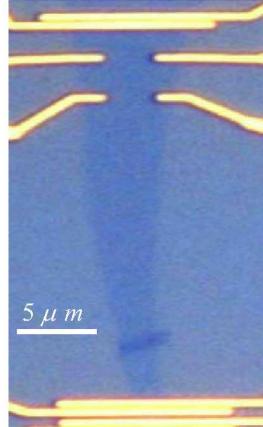
Break A-B  
degeneracy  
→ bandgap

Bonding/anti-bonding  
states of two layers  
→ split into 4 bands



$$E = \frac{\hbar^2 k^2}{2m^*}$$

# Quantum Hall Effect: Single Layer vs. Bilayer

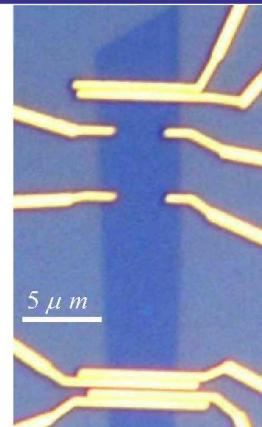
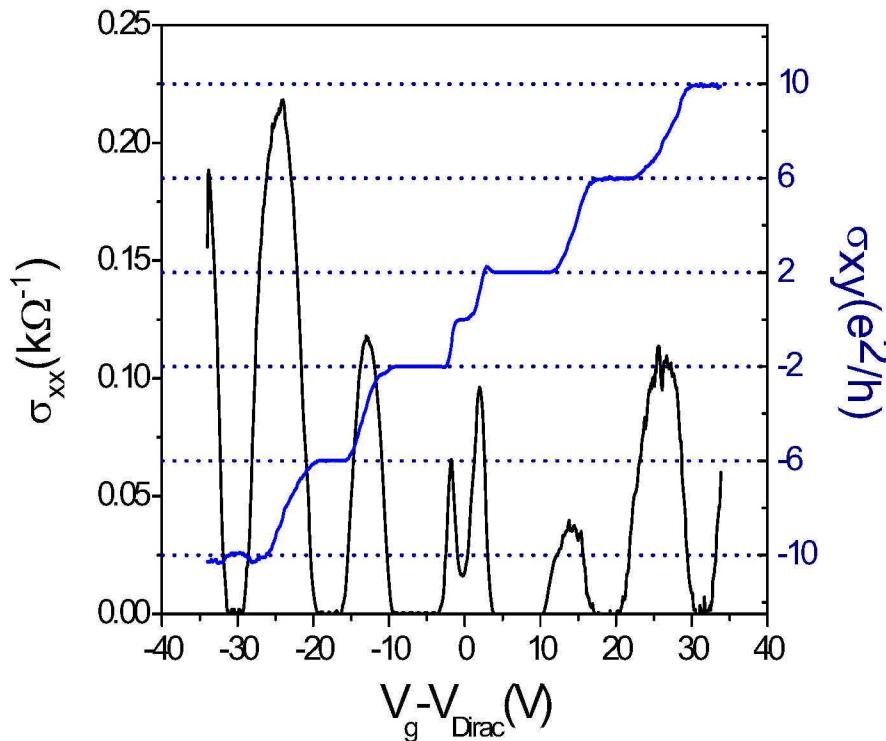


Single layer:

$$\sigma_{xy} = \nu \frac{e^2}{h} \quad \nu = 4\left(n + \frac{1}{2}\right)$$

Berry's phase =  $\pi$

QHE single layer at T=1.34K B=9T

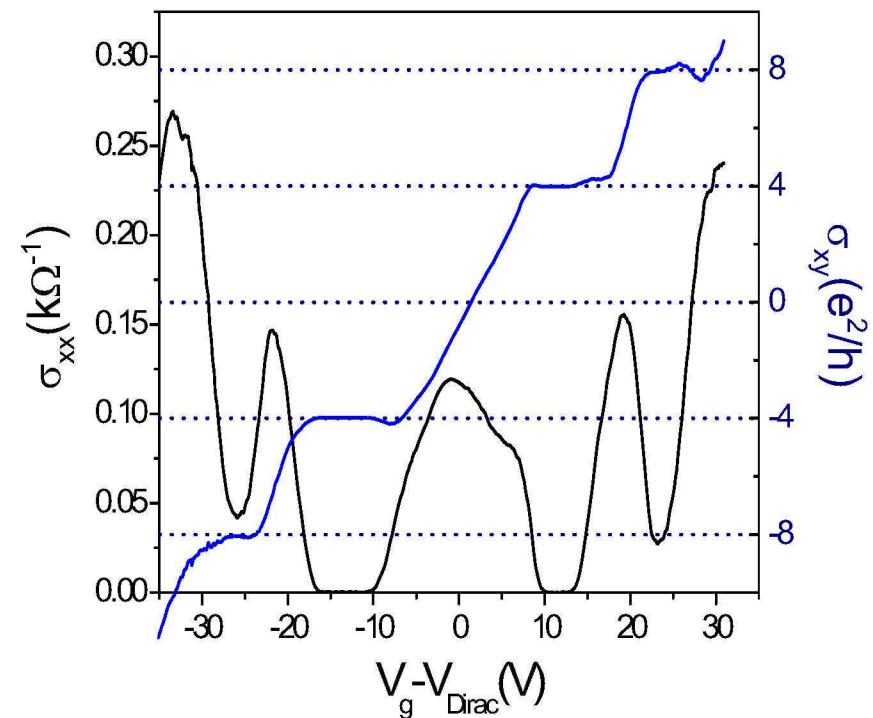


Bilayer:

$$\sigma_{xy} = \nu \frac{e^2}{h} \quad \nu = 4(n+1)$$

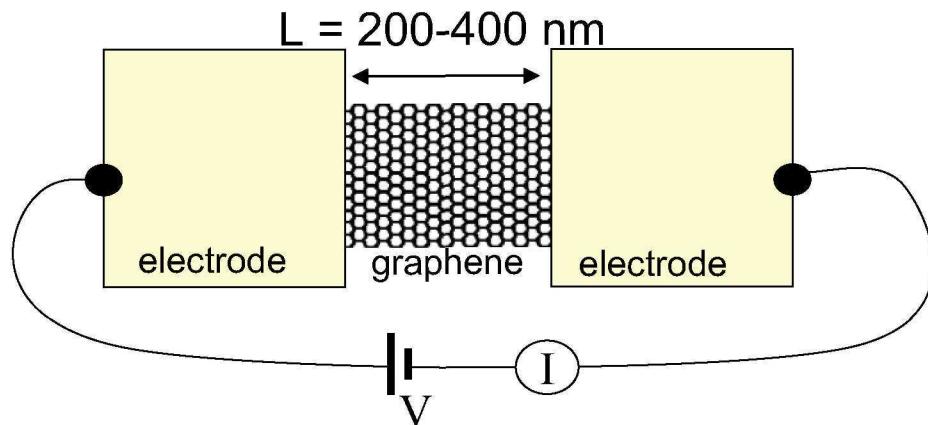
Berry's phase =  $2\pi$

bilayer QHE at T=1.35K, B=9T



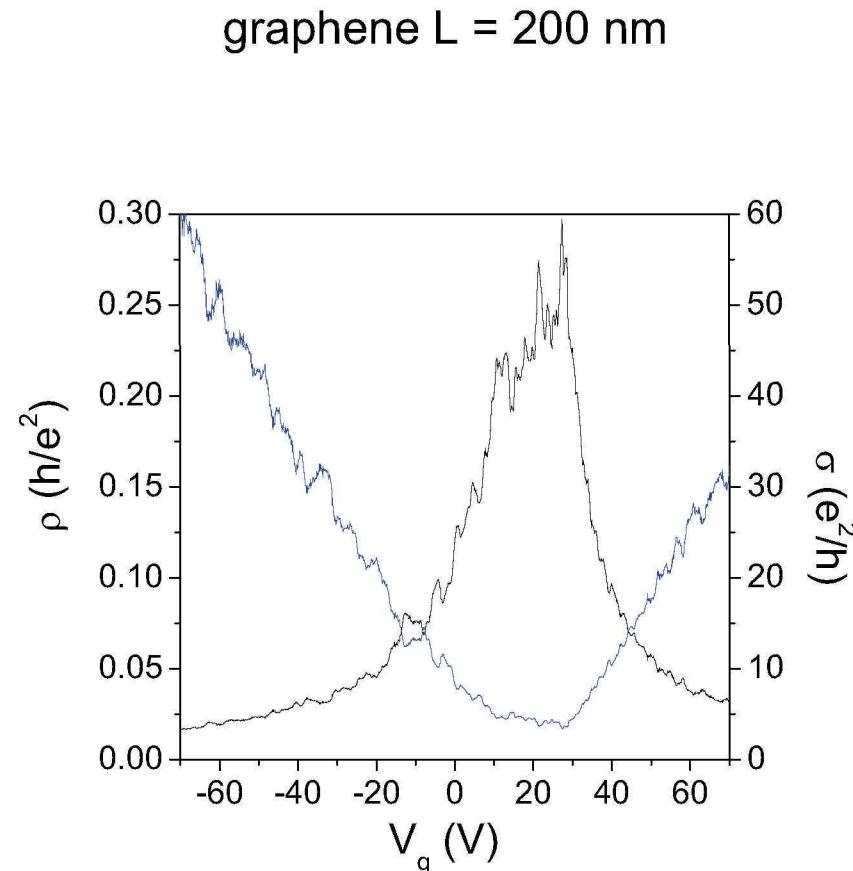
See also: Zhang et al, 2005, Novoselov et al, 2005.

# Fabry-Pérot Interference in CNT and Graphene

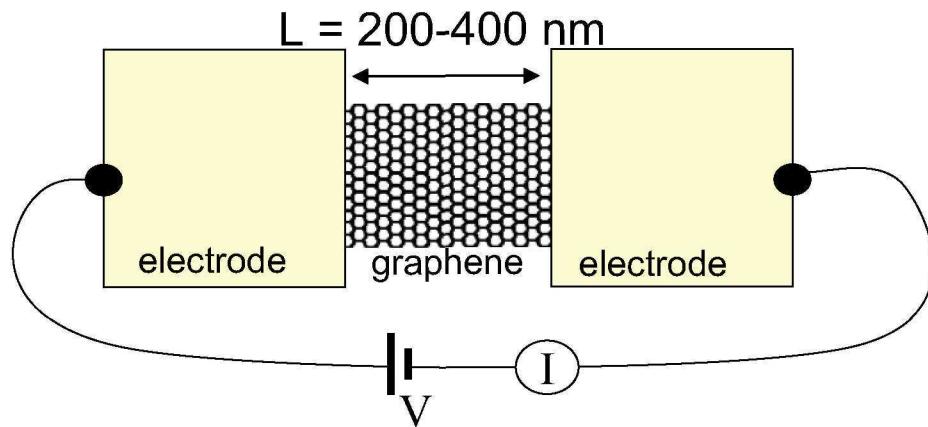


Short two-probe devices ( $L \sim \text{mfp}$ )

- Two-probe differential conductance shows oscillations as a function of gate and drain voltage
- NOT universal conductance fluctuations (UCF)

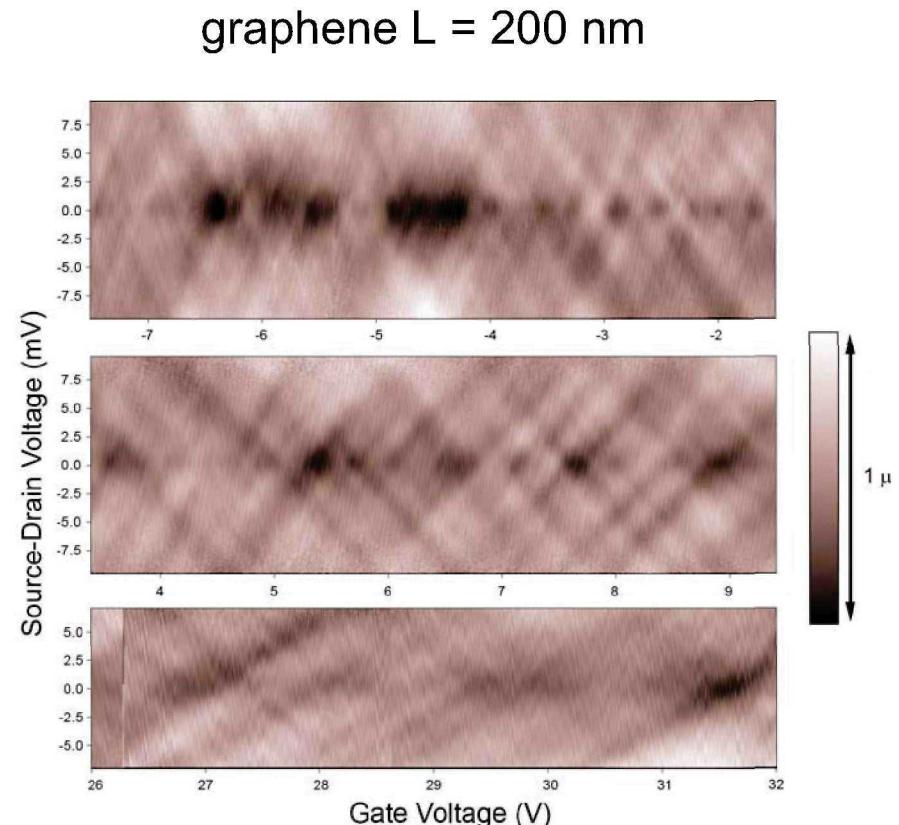


# Fabry-Pérot Interference in CNT and Graphene



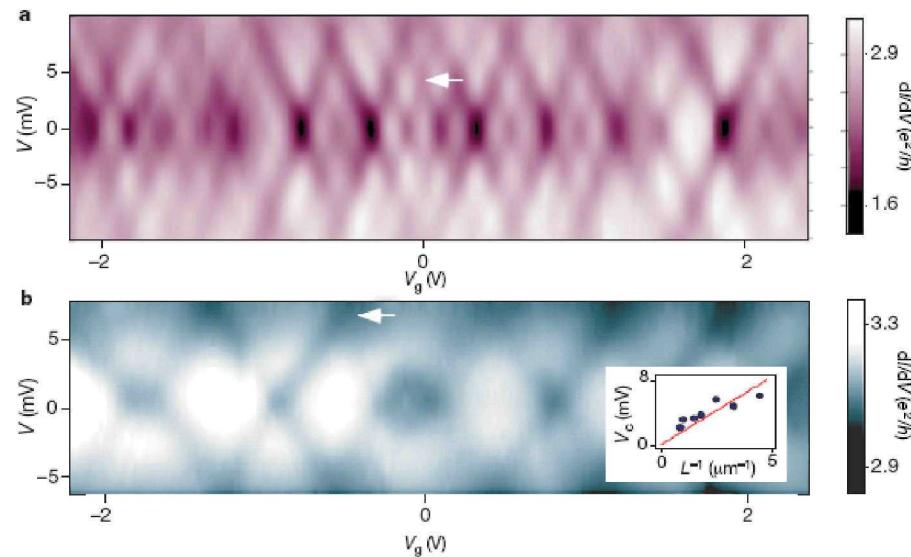
Short two-probe devices ( $L \sim \text{mfp}$ )

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- NOT universal conductance fluctuations (UCF)



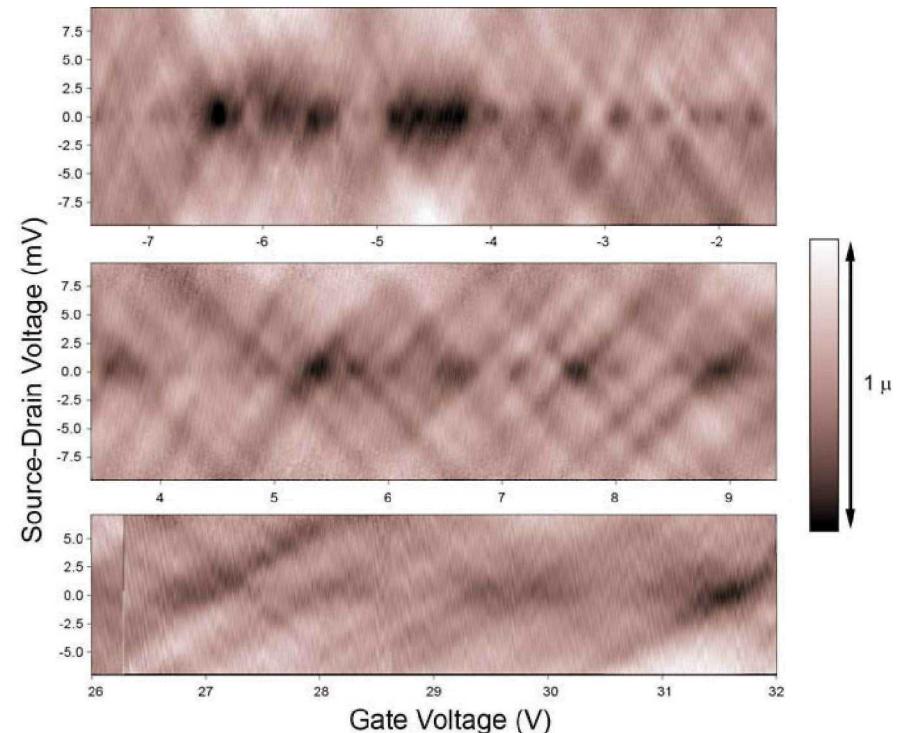
# Fabry-Pérot Interference in CNT and Graphene

Similar phenomena observed in metallic CNTs



Metallic CNT:  
Liang, et al. Nature **411**, 665 (2001)

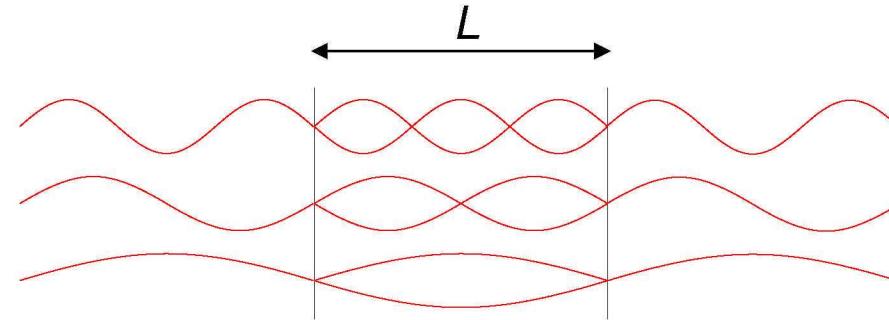
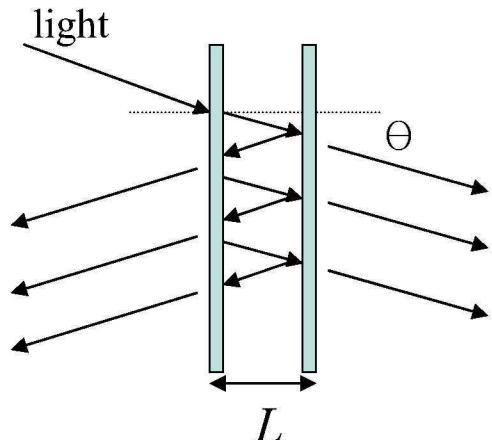
graphene  $L = 200$  nm



Graphene:  
F. Miao, cond-mat/0703052 (2007)  
S. Cho and M. S. Fuhrer, unpublished.

# Fabry-Pérot Interferometer

Light is transmitted when resonance occurs:



Resonance condition is:

$$L = n \frac{\lambda}{2} = n \frac{\pi}{k} \rightarrow k_n = \frac{n\pi}{L}$$

Identical to particle-in-a-box states!

Light-like  
particles:

$$k = \frac{n\pi}{L}$$

$$E_n = \hbar v_F k_n = n \frac{\hbar v_F \pi}{L}$$

Michael S. Fuh

Massive  
particles:

$$k = \frac{n\pi}{L}$$

$$E_n = \frac{\hbar^2 k_n^2}{2m} = n^2 \frac{\hbar^2}{8mL^2}$$

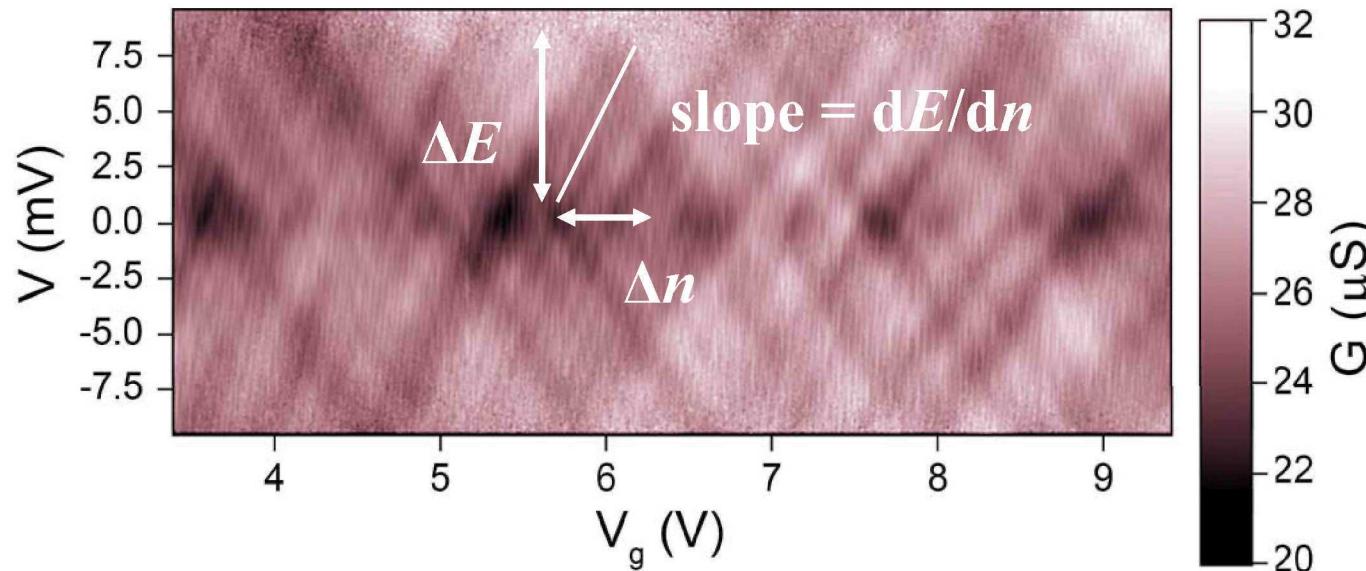
d

# Fabry-Pérot Interference in CNT and Graphene

Simple picture:

$V$  measures spacing of resonances in energy

$V_g$  measures spacing of resonances in particle density



slope is proportional to  $dE/dn = 1/D(E)$

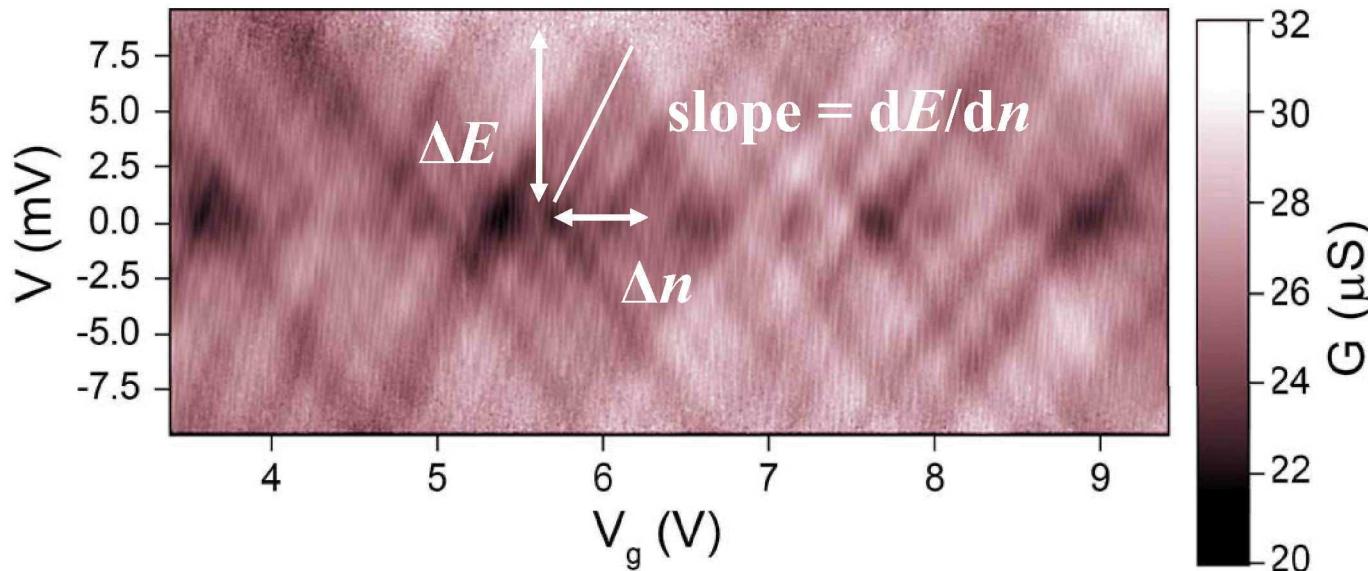
$D(E)$  is density of states in energy

# Fabry-Pérot Interference in CNT and Graphene

Simple picture:

$V$  measures spacing of resonances in energy

$V_g$  measures spacing of resonances in particle density



More careful treatment:

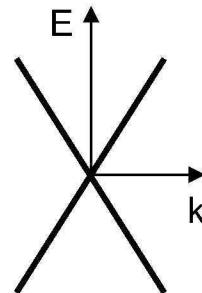
$$\text{slope} = \frac{\Delta V}{\Delta V_g} = \frac{\frac{h\nu_F}{eL}}{\frac{e}{c_g} \frac{h\nu_F}{2L} D(E)} = \frac{2c_g}{e^2} \frac{1}{D(E)}$$

## Two-dimensional particle-in-a-box

### Massless: Single-layer graphene

$$E = \hbar v_F |\mathbf{k}|$$

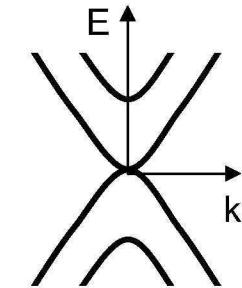
$$v_F = 1 \times 10^6 \text{ m/s}$$



### Massive: Bilayer graphene

$$E = \frac{\hbar^2 k^2}{2m^*}$$

$$m^* = 0.031 m_e$$



Particle in a box:  $L = \frac{n\lambda}{2}$        $\mathbf{k} = (k_x, k_y) = \left( p \frac{\pi}{L}, q \frac{\pi}{L} \right)$        $p, q = \text{integer}$

$$E = hf\sqrt{p^2 + q^2}$$

$$E \propto k$$

$$E = \frac{\hbar^2(p^2 + q^2)}{8m^* L^2}$$

$$E \propto k^2$$

Fermions:  $N = \frac{gk_F^2 L^2}{4\pi}$       g is degeneracy

Fermi energy:  $E_F = \hbar v_F \sqrt{\pi n}$

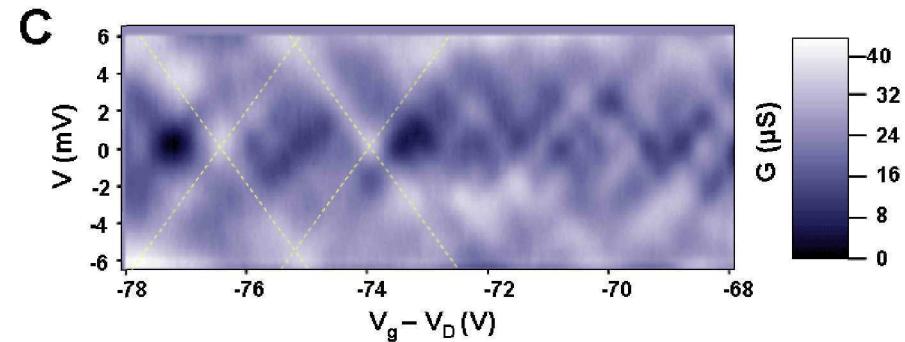
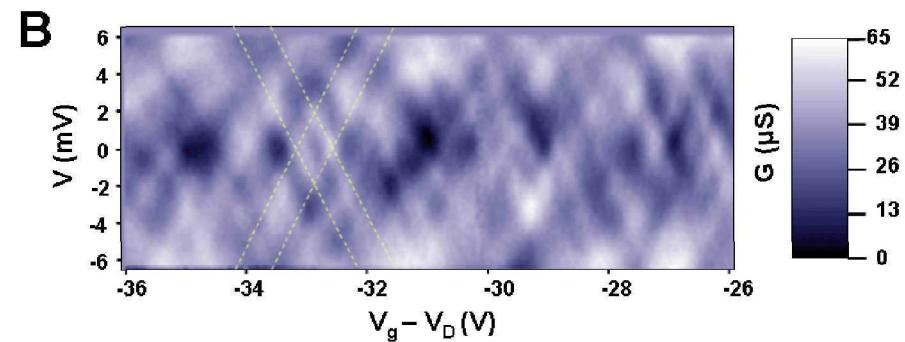
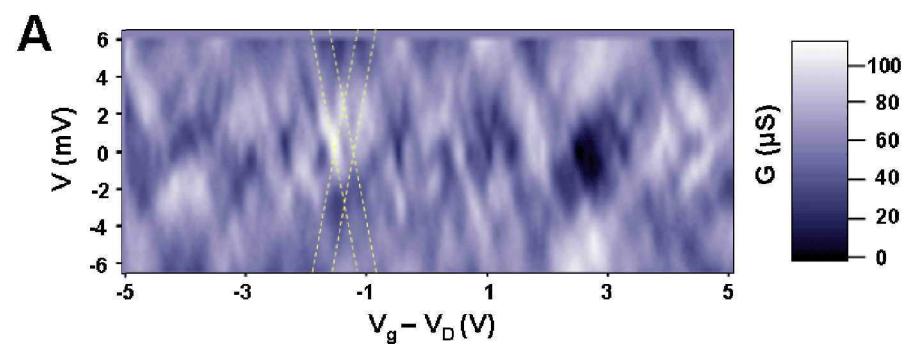
Fermi energy:  $E_F = \frac{\pi \hbar^2 n}{2m^*}$

Density of states:  $D = \frac{1}{\hbar v_F} \sqrt{\frac{gn}{\pi}} \propto n^{1/2}$

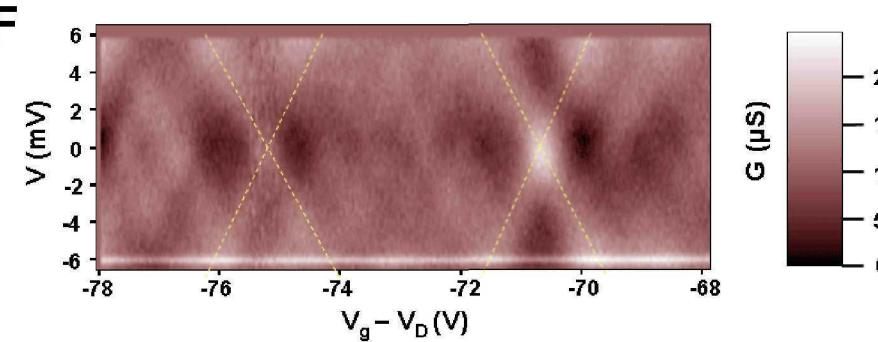
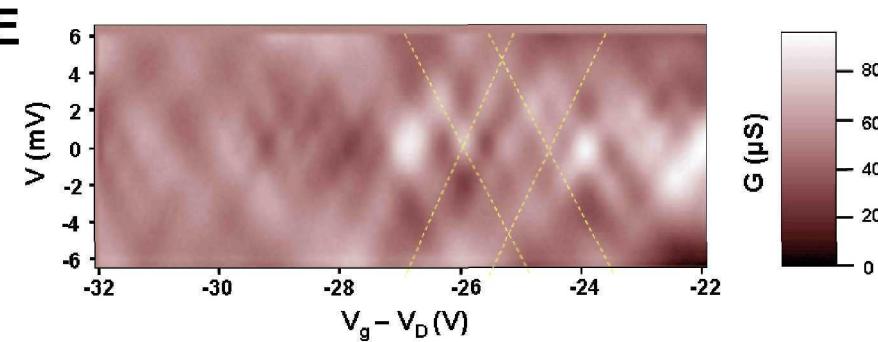
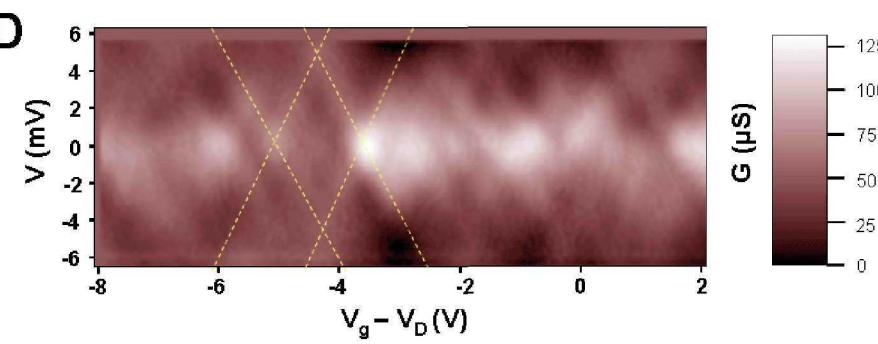
Density of states:  $D = \frac{gm^*}{2\pi\hbar^2}$  indep. of n

# Gate voltage dependence of the slopes

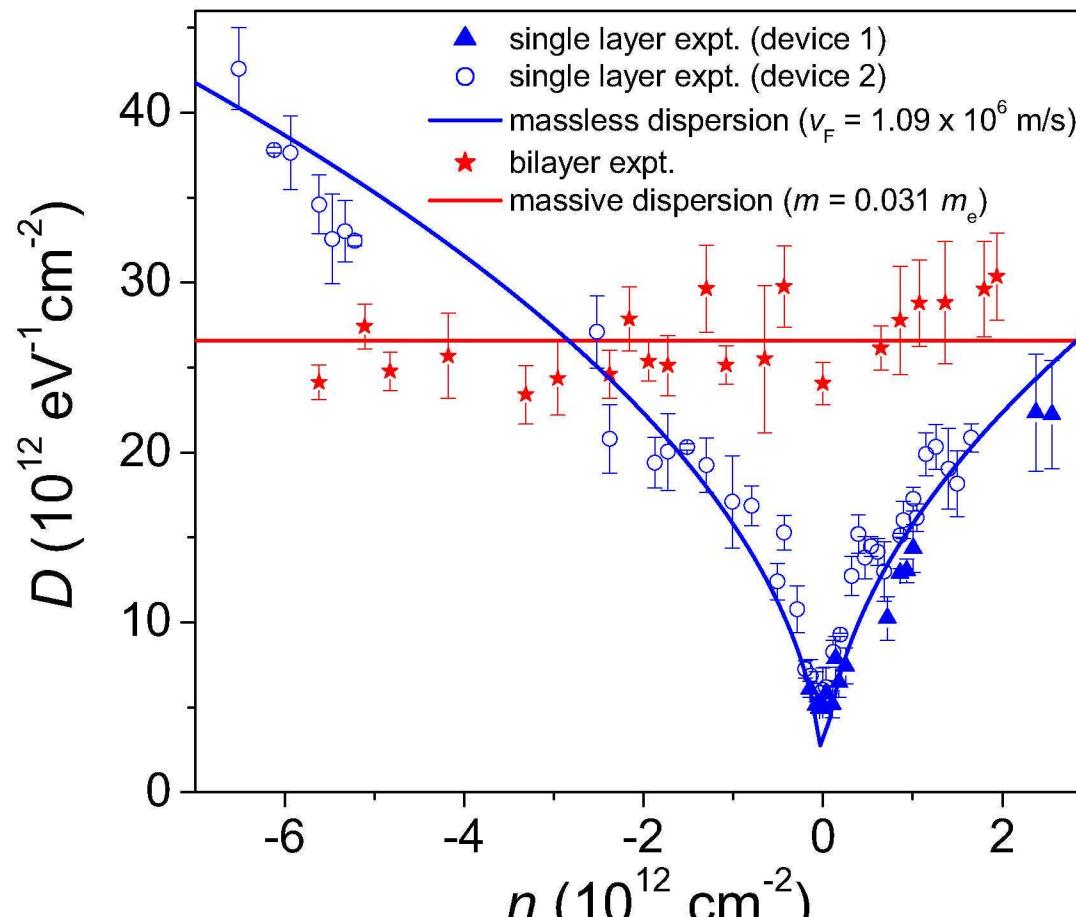
## Single Layer



## Bilayer



# Density of States: Single layer and Bilayer



$$slope = \frac{\Delta V}{\Delta V_g} = \frac{2c_g}{e^2} \frac{1}{D(E)}$$

Fits:

Single layer

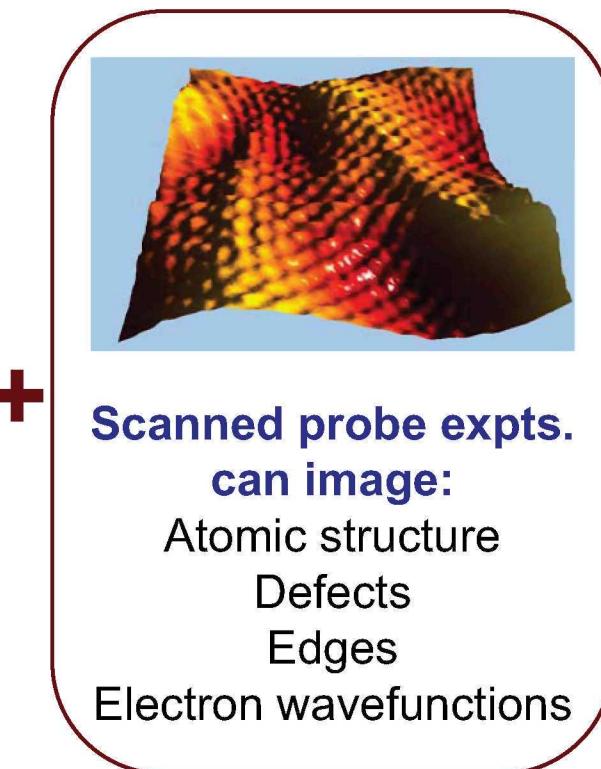
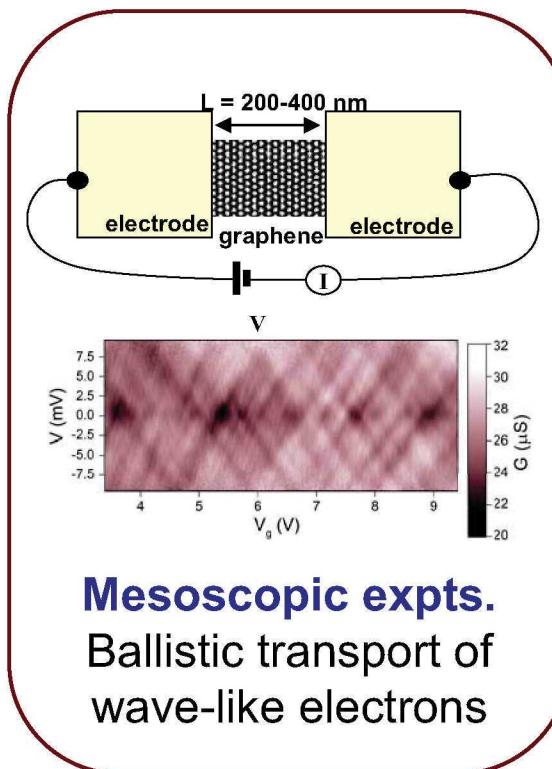
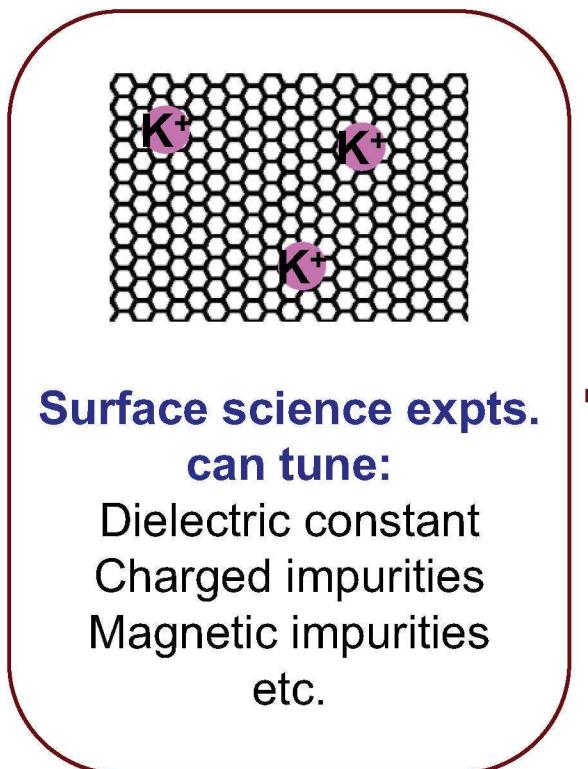
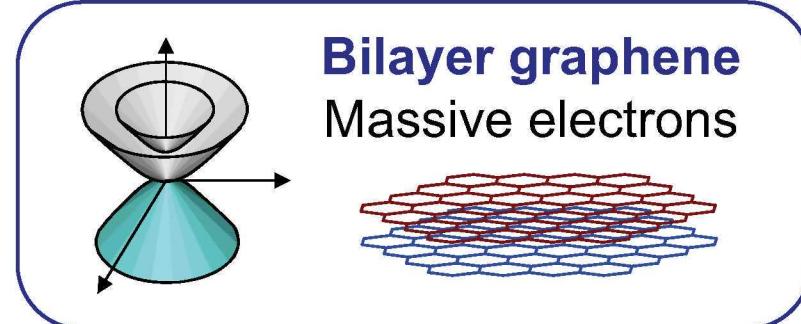
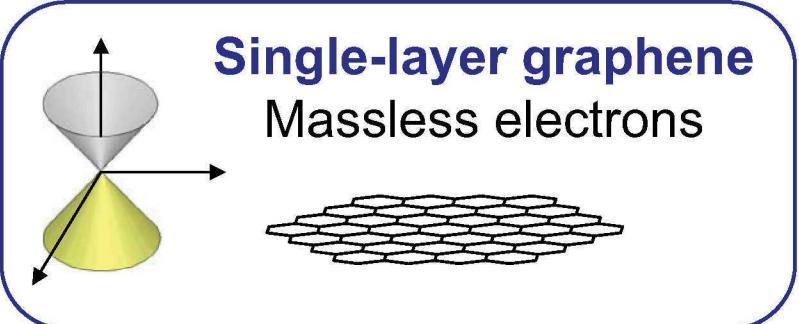
$$D(E) = \frac{1}{\hbar v_F} \sqrt{\frac{4n}{\pi}}$$

$v_F = 1 \times 10^6 \text{ m/s}$

$D(E) = \frac{2m^*}{\pi \hbar^2}$

$m^* = 0.031 m_e$

# Outlook



## Prof. Michael S. Fuhrer's Group

Sungjae Cho

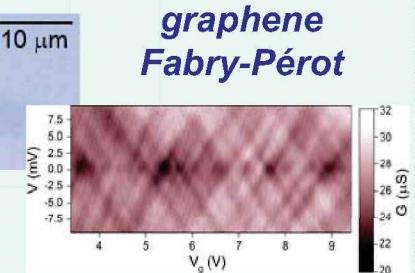
Chaun Jang

Shudong Xiao

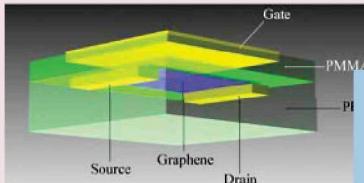
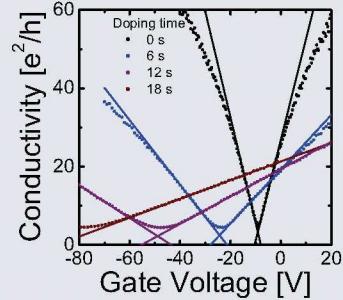
Alexandra Curtin



MR in graphene

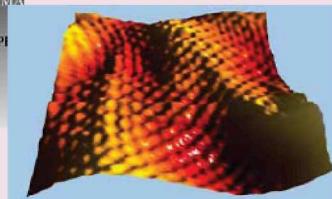


UHV  
doping,  
dielectric expts.



transfer-printing

STM



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